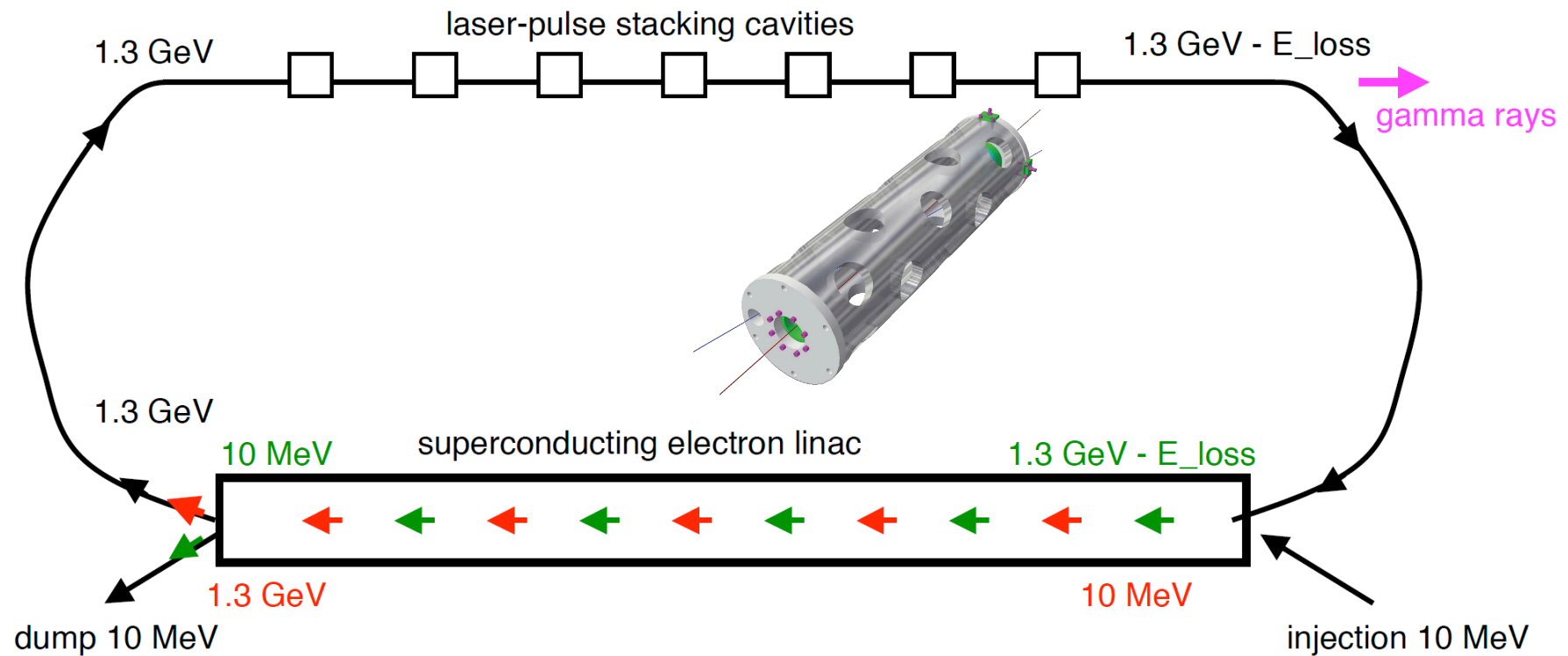


# ERL based Compton scheme & requirements to lasers

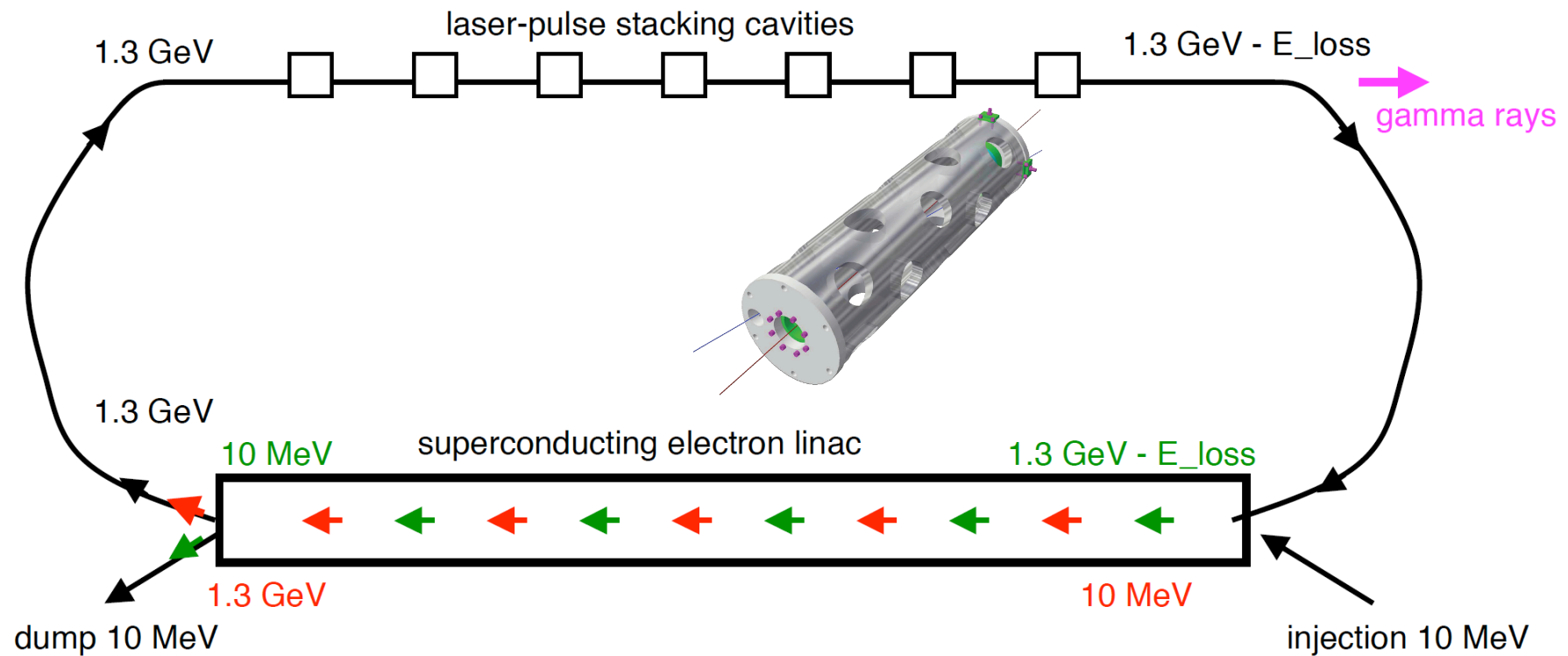


**Tsunehiko OMORI (KEK)**

**PosiPol2007@LAL**

**23/May/2007**

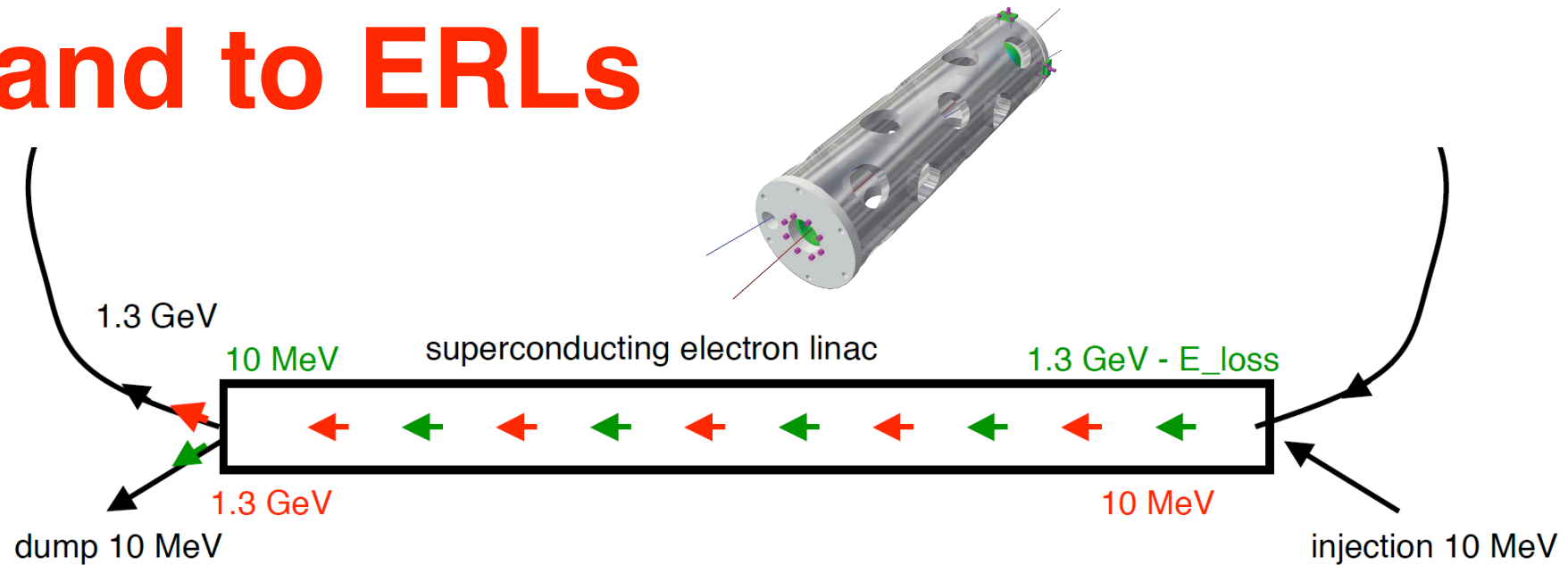
# ERL based Compton scheme & requirements to lasers



my talk is inspired by  
Variola-san's talk at KEK Nov/2006 and  
Rainer-san's suggestion at SLAC Apr/2004

**Tsunehiko OMORI (KEK)**  
**PosiPol2007@LAL**  
**23/May/2007**

# ERL based Compton scheme & requirements to lasers, to $e^+$ stacking, to capture, and to ERLs



my talk is inspired by  
Variola-san's talk at KEK Nov/2006 and  
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# World-Wide Compton Collaboration

Collaborating Institutes:

BINP, CERN, DESY, Hiroshima, IHEP, IPN, KEK,  
Kyoto, LAL, NIRS, NSC-KIPT, SHI, Waseda,  
BNL, JAEA, and ANL

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Takashi Taniguchi, Nobuhiro Terunuma, Junji Urakawa, X. Artru, M. Chevallier, V. Strakhovenko,  
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**Red : New people since Posipol2006**

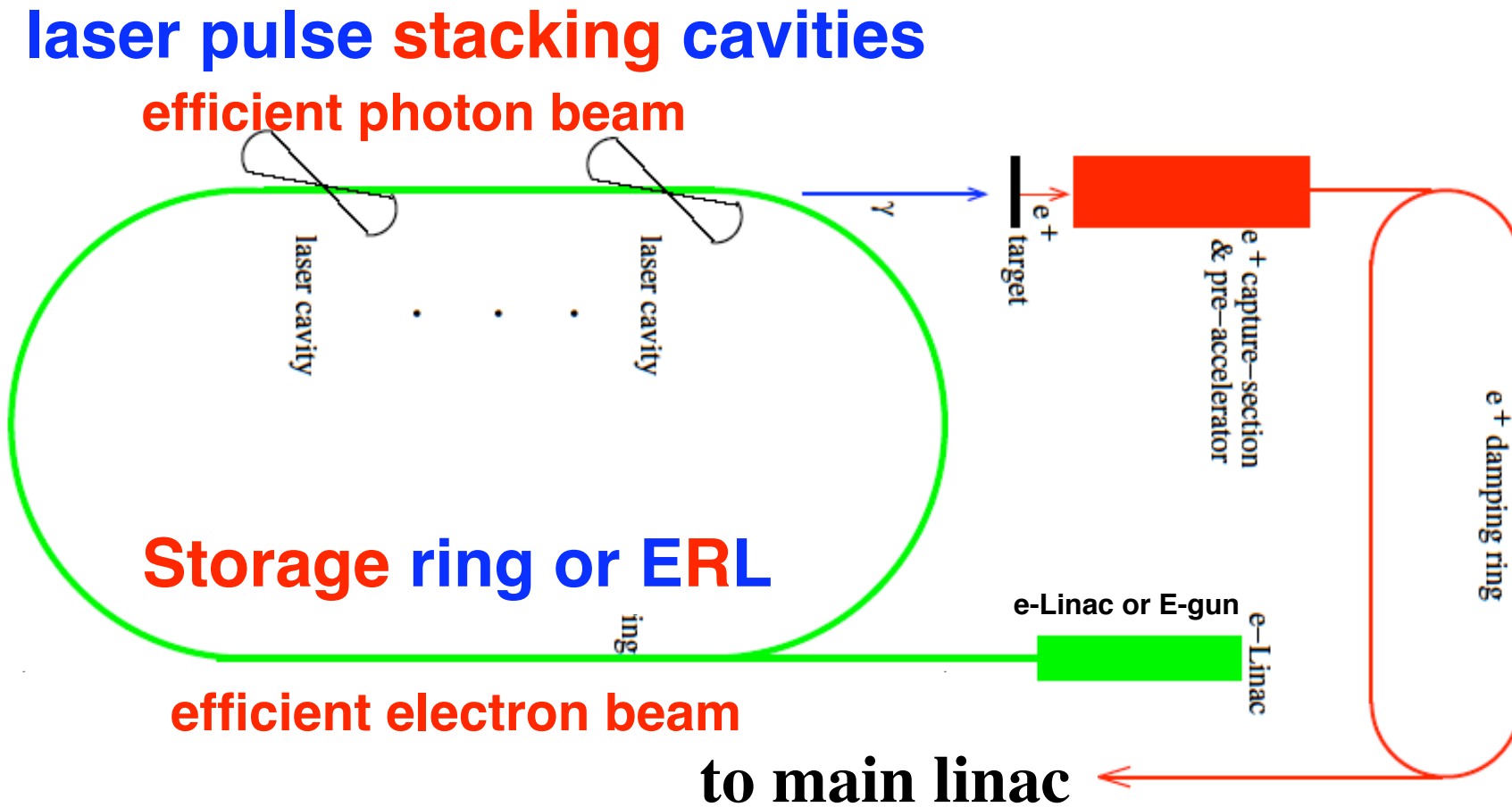
# Today's Talk

**Aim : to get working-assumption-  
models of ERL scheme**

**I will consider many constraints  
and show two models.**

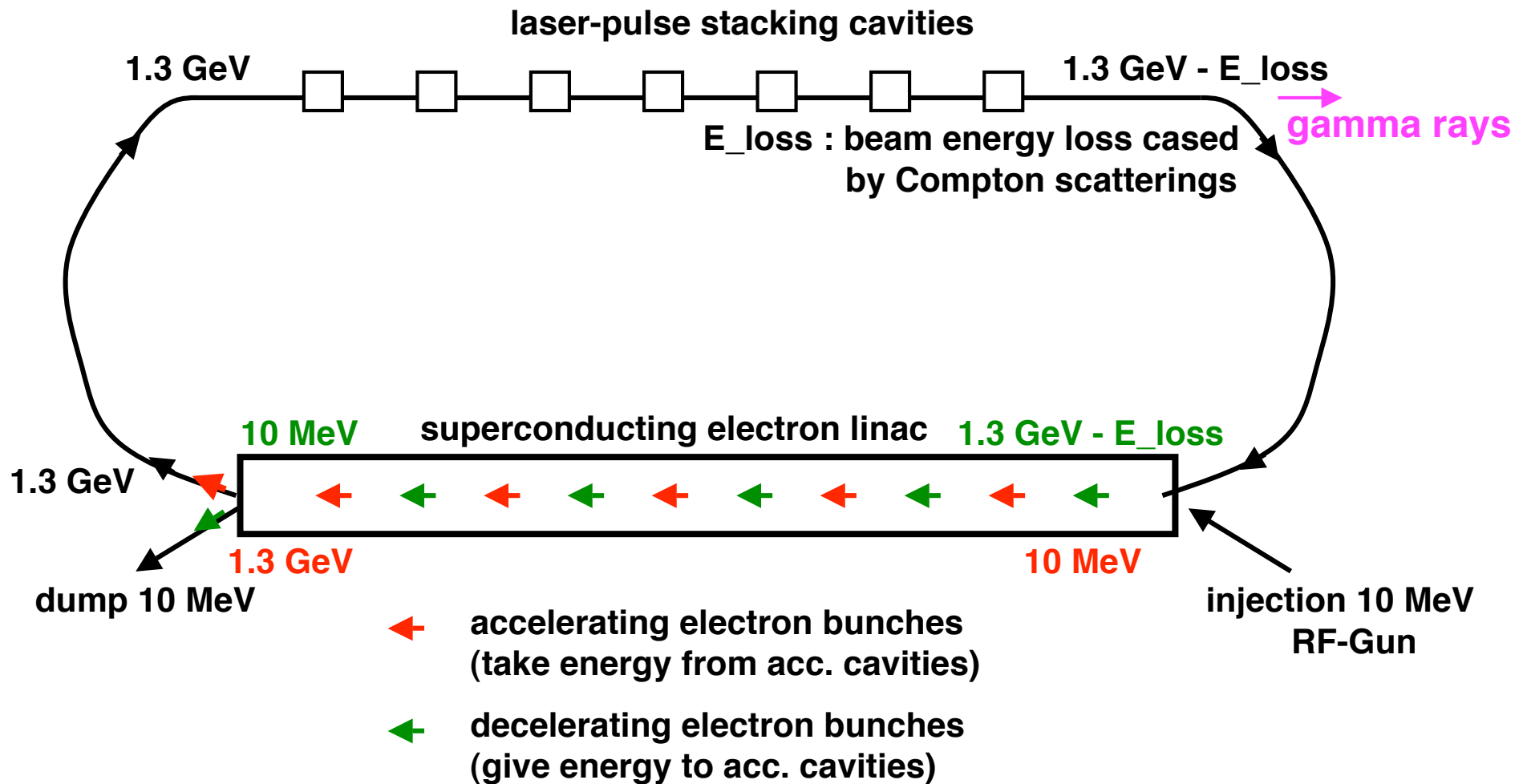
# Ring/ERL Compton Re-use Concept

positron stacking in main DR



# What is ERL?

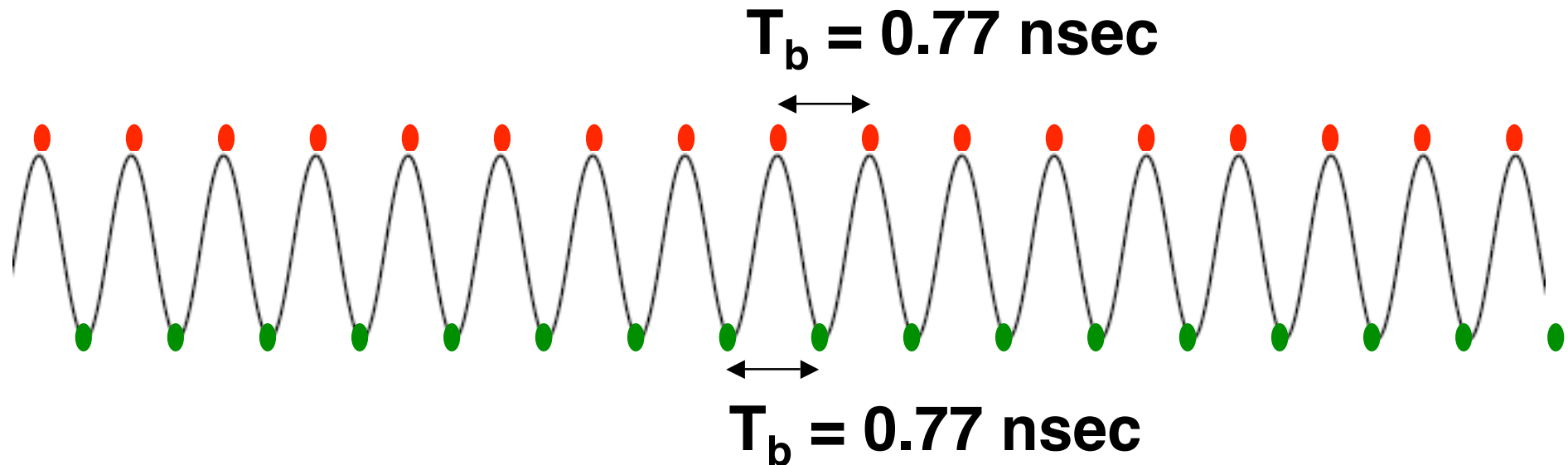
## What is ERL based Compton source?





# What is ERL?

**e<sup>-</sup> bunches in ERL (  $f_{RF} = 1.3$  GHz)**



- Accelerating bunches
- Decelerating bunches

$T_b$  : bunch to bunch separation

# **Points of ERL 1**

**Re use: Energy of electron beam.**

**Throw away: electron beam.**

## **Points of ERL 1**

**Re use: Energy of electron beam**

**Throw away: electron beam.**

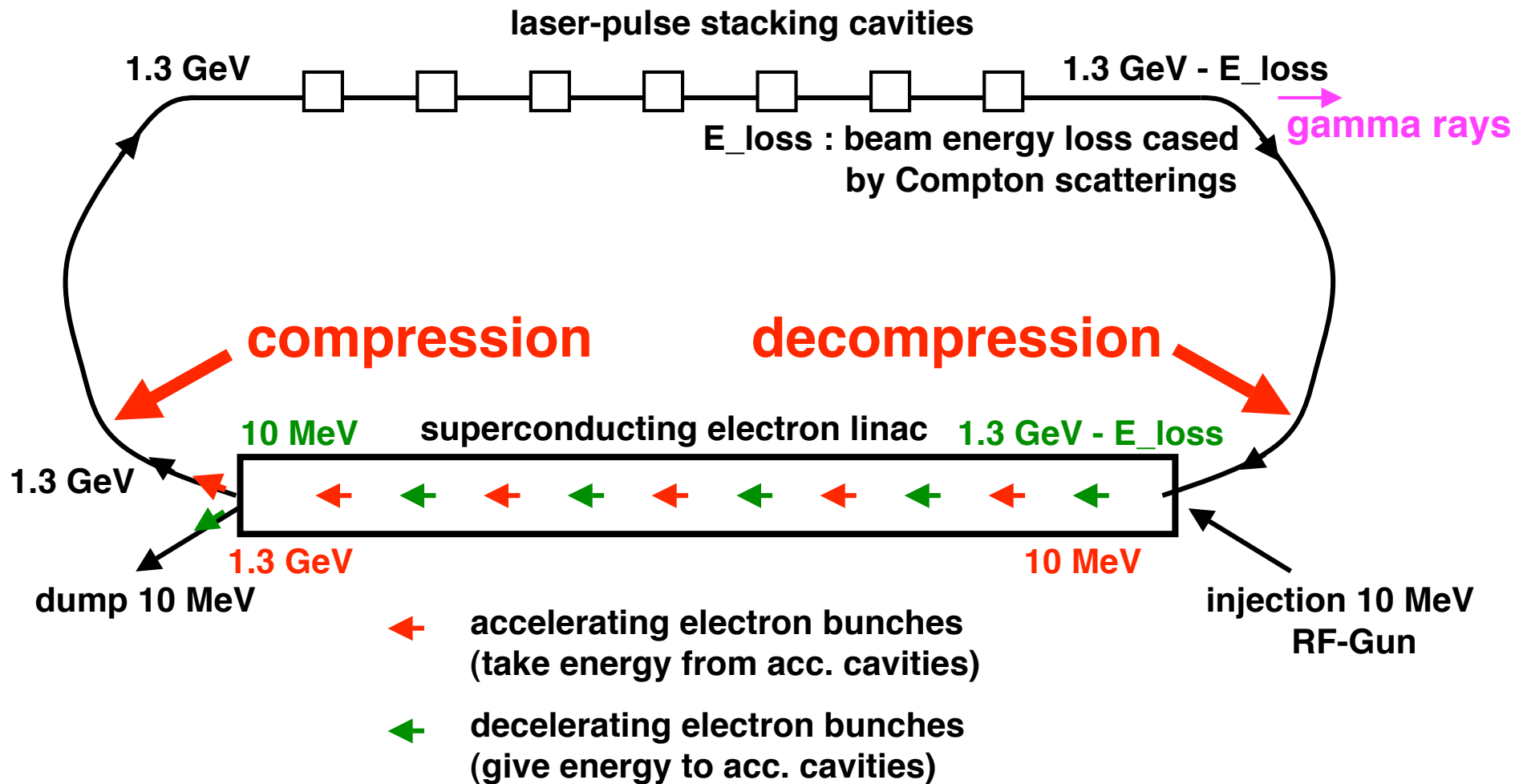
## **Points of ERL 2**

**Fresh, high quality beam.**

**Easy beam **compression.****

# What is ERL?

## What is ERL based Compton source?



## **Points of ERL 1**

**Re use: Energy of electron beam**

**Throw away: electron beam.**

## **Points of ERL 2**

**Fresh, high quality beam**

**Easy beam compression**

## **Points of ERL 3**

**Need steady exchange of energy:**

**Acc-Bunches, Decl-Bunches, Klystrons**

**Need CW operation**

## **Points of ERL 1**

**Re use: Energy of electron beam**

**Throw away: electron beam.**

## **Points of ERL 2**

**Fresh, high quality beam**

**Easy beam compression**

## **Points of ERL 3**

**Need steady exchange of energy:**

**Acc-Bunches, Decl-Bunches, Klystrons**

**Need CW operation**

# Injection : ERL --> DR

**Constraint 1 : ERL needs CW operation**

**choice: quasi-CW operation**

**1) first 100 msec**

**ERL operation + top-up injection to DR**

**very different from storage ring scheme**

**2) 2nd 100 msec**

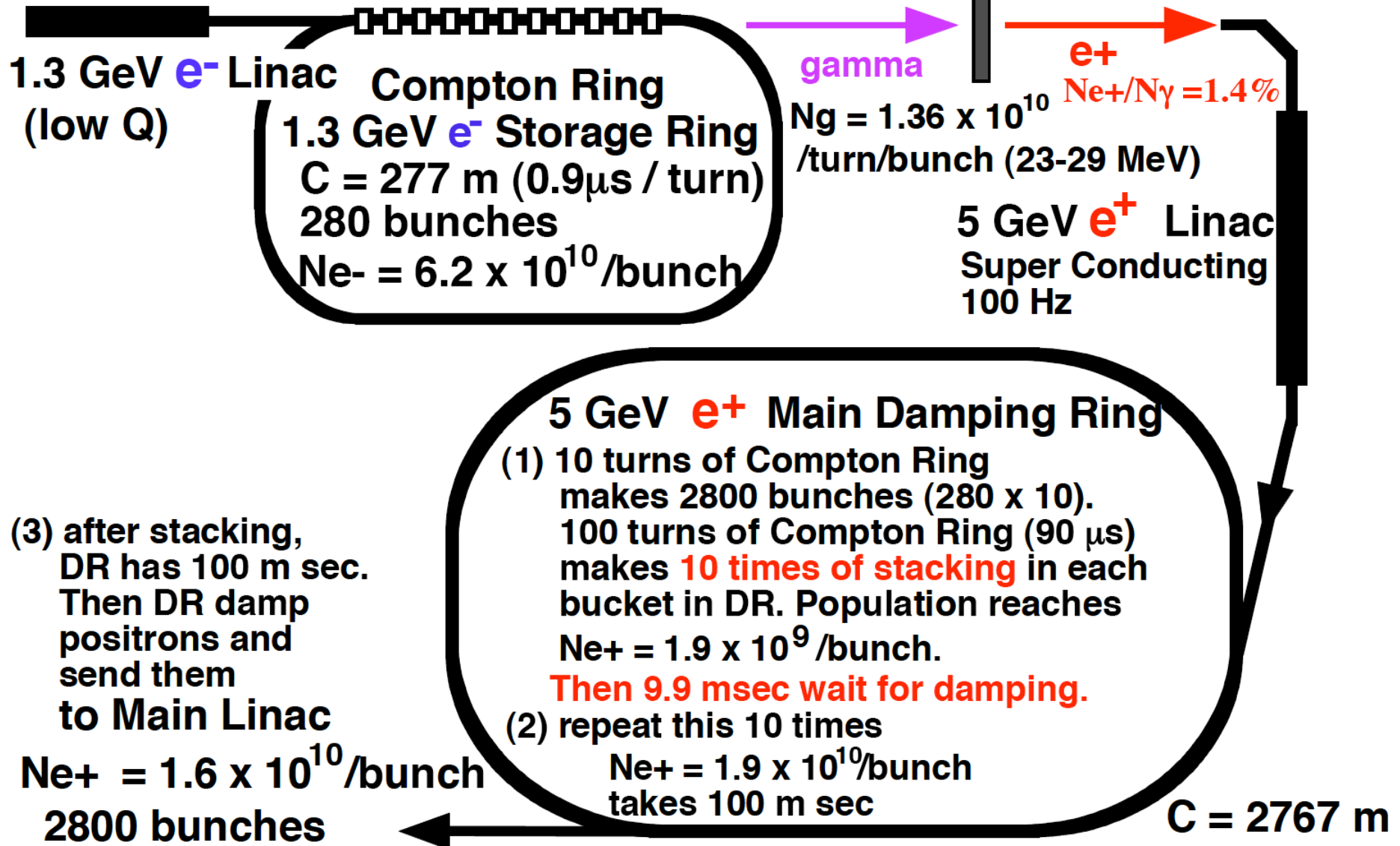
**damping in DR**

# Snowmass 2005 Ring based Compton

## 30 YAG Laser Pulse Stacking Cavities

600 mJ in each cavity, 8 degree crossing to e- beam  
(collisions in 100 turns + 9.9 msec cooling)x100 Hz

Ne+ =  $1.9 \times 10^8$ /bunch  
280 bunches





# Snowmass 2005 Ring based Compton

## Burst injection

1) first 100 m sec

10 x (injection 0.1 ms + damping 9.9 ms)  
required by both DR and Compton ring

--->

total : injection 1 ms + damping 99 ms

2) second 100 m sec

damping in DR

# Snowmass 2005 Ring based Compton

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ERL scheme --> top-up injection

**injection 100 ms**

top-up injection

**possible? working assumption**

# Snowmass 2005 Ring based Compton

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damping in DR

ERL scheme --> top-up injection

**injection 100 ms**

top-up injection

**possible? working assumption**

**x 100  
gain**



**ERL scheme has "x100 gain" in time**

**Tight e<sup>+</sup> selection in the Capture system**

**Get better emittance of e<sup>+</sup> in Capture**

**typical capture:**  $N_{e^+ \text{ (Captured)}} / N_{\gamma} \sim 2 \%$



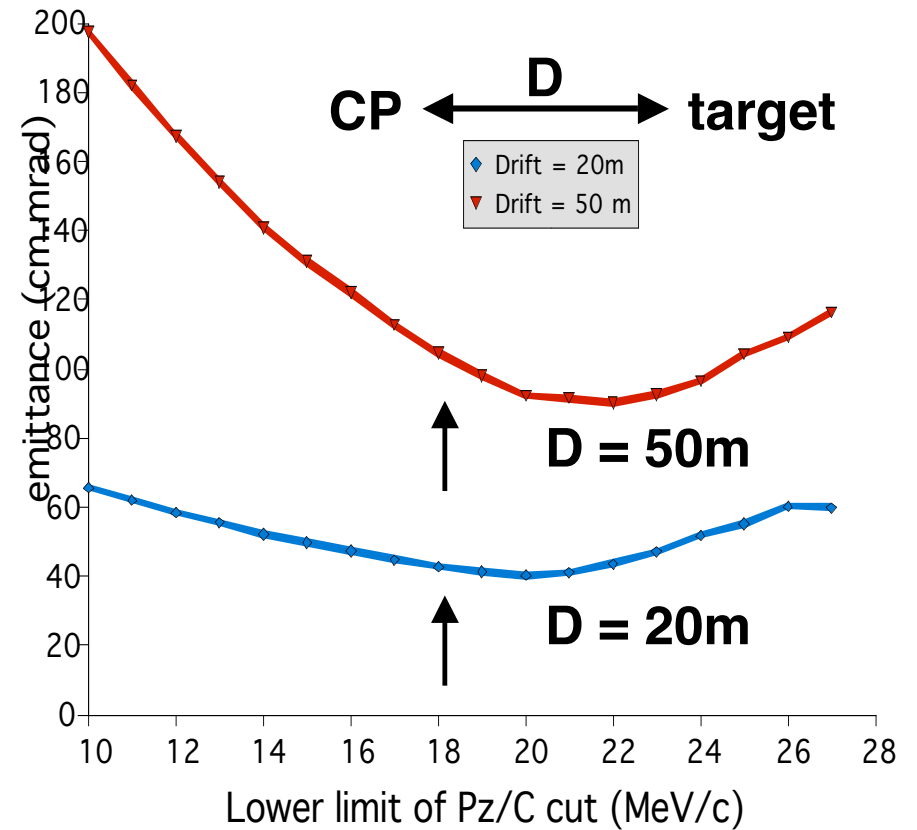
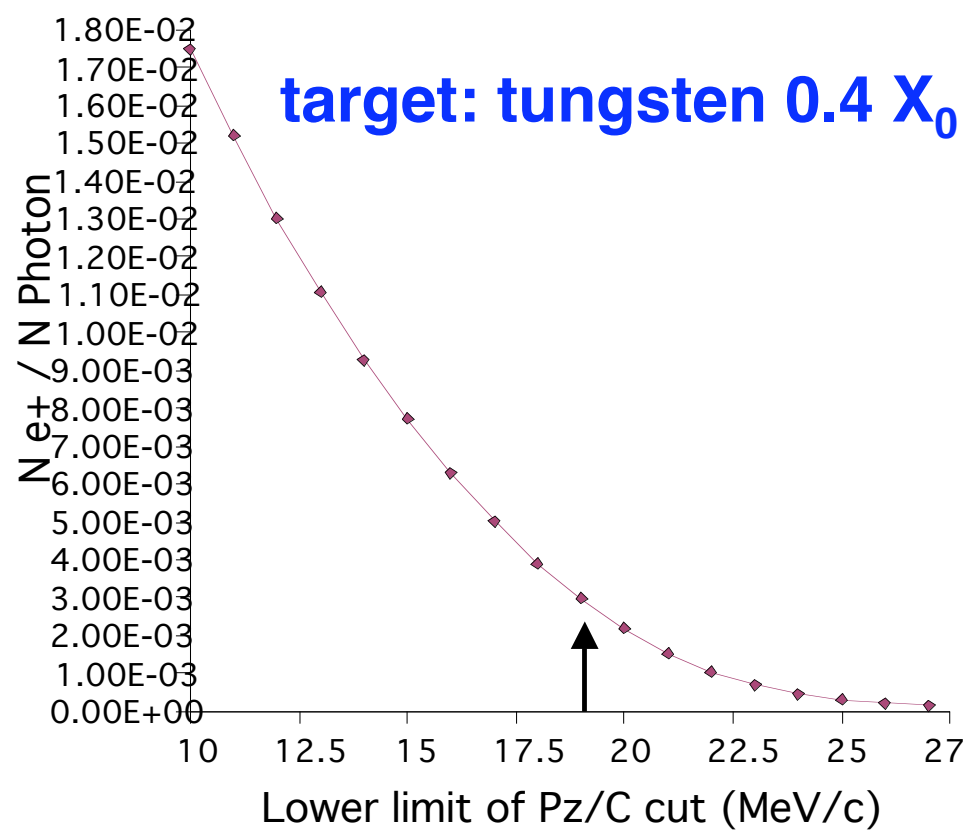
**intentional reduction  
to get better  $\varepsilon$**

**Proposal:**  $N_{e^+ \text{ (Captured)}} / N_{\gamma} \sim 0.3 \%$

**How to reduce  $N_{e^+}$  ?**

- (1) Pz selection**
- (2) reduce target thickness**
- (3) combination of (1) and (2)**

# Preliminary study by Wanming & Wei (ANL)



**if  $P_z > 18 \text{ MeV/c} \rightarrow N_{e^+}/N_{\gamma} \sim 0.3\% \quad \text{Pol} \sim 80\%$**

**$\epsilon(\text{geo})$  at target exit  $\sim 100 \text{ cm-mrad}$  (D=50m)**

**$\sim 50 \text{ cm-mrad}$  (D=20m)**

# Injection : ERL --> DR

**Constraint 1 : ERL needs CW operation**

**choice: quasi-CW operation**

**1) first 100 msec**

**ERL operation + top-up injection to DR**

**very different from storage ring scheme**

**2) 2nd 100 msec**

**damping in DR**

**Constraint 2 :  $T_{b\_ERL} = nT_{b\_DR}$**

**Constraint :  $T_b$  in ERL  $\leftrightarrow$   $T_b$  in DR**

$$T_{b\_ERL} = nT_{b\_DR} \quad (n=1, 2, 3, \dots)$$

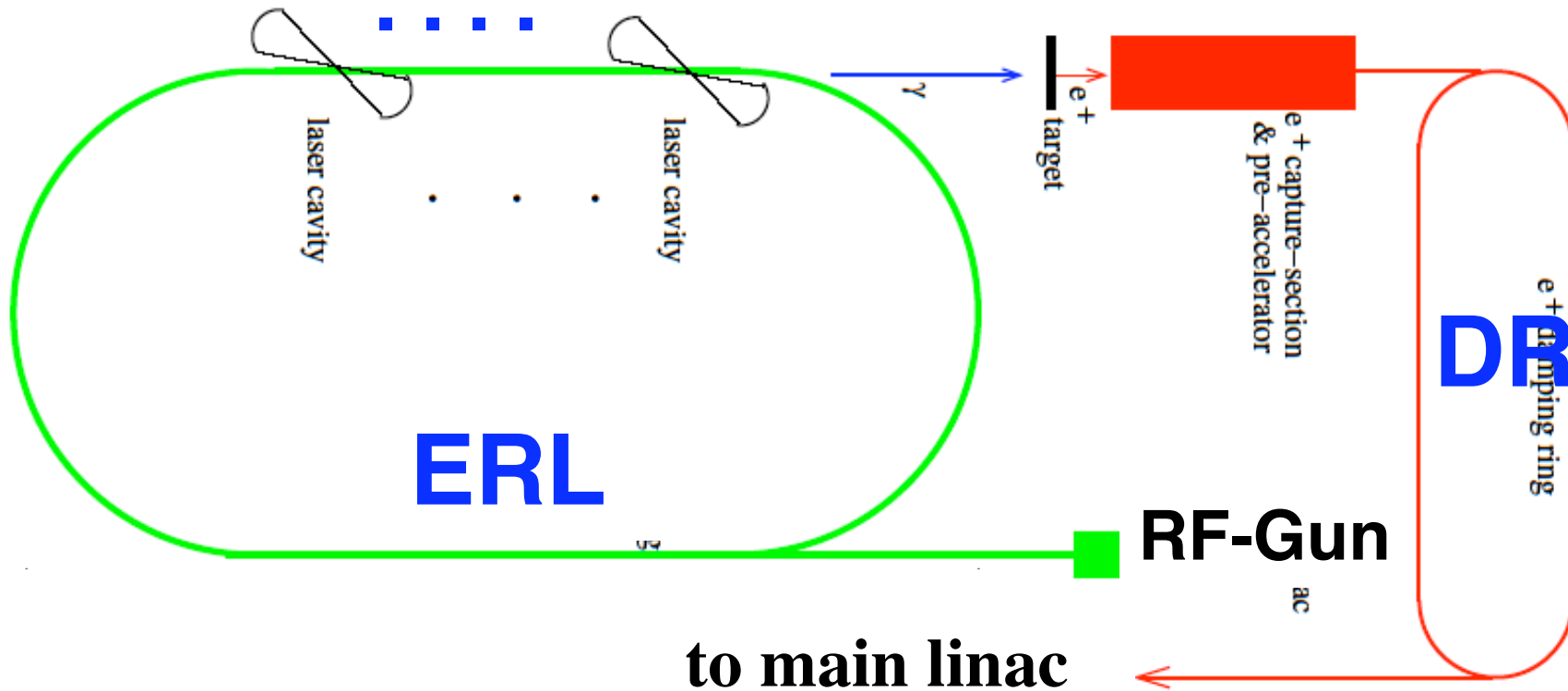
$T_{b\_ERL} = 6.15 \text{ nsec}$

$T_{b\_DR} = 6.15 \text{ nsec}$

12.3 nsec

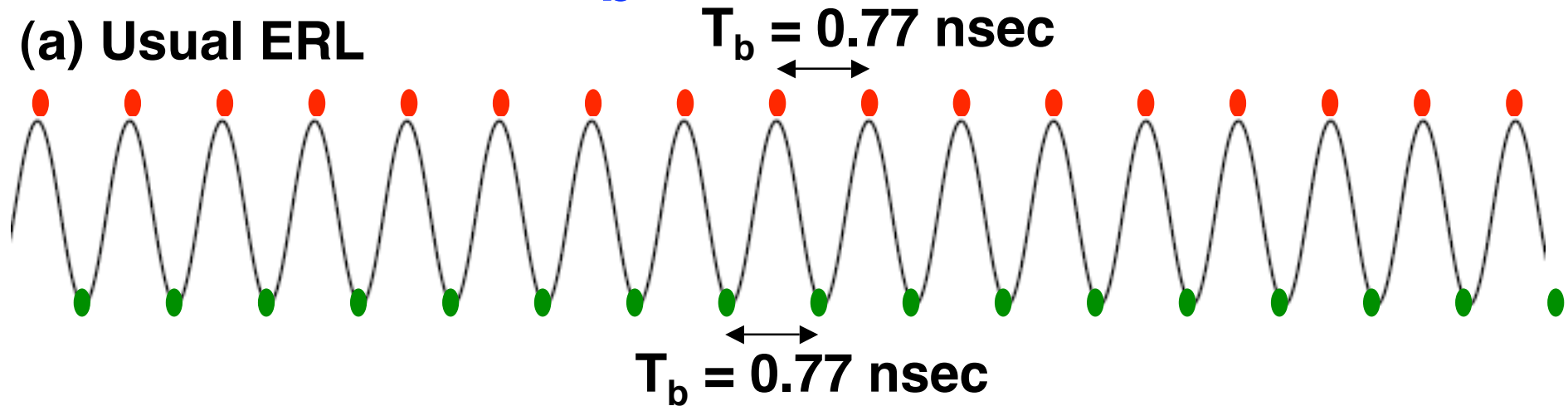
18.5 nsec

.....

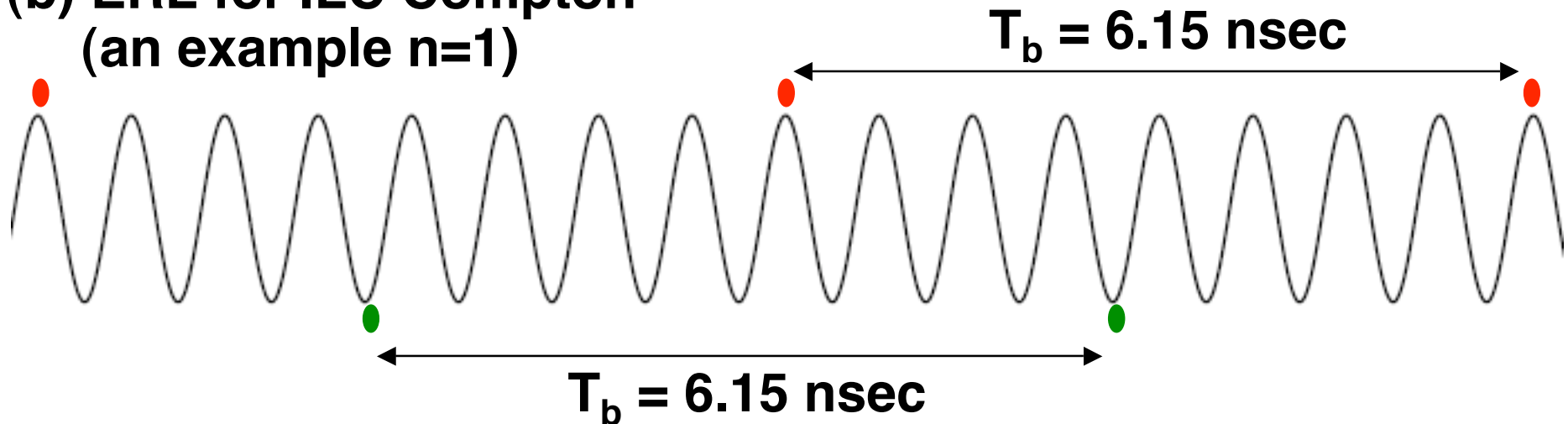


# Constraint : $T_b$ in ERL

(a) Usual ERL



(b) ERL for ILC Compton  
(an example  $n=1$ )

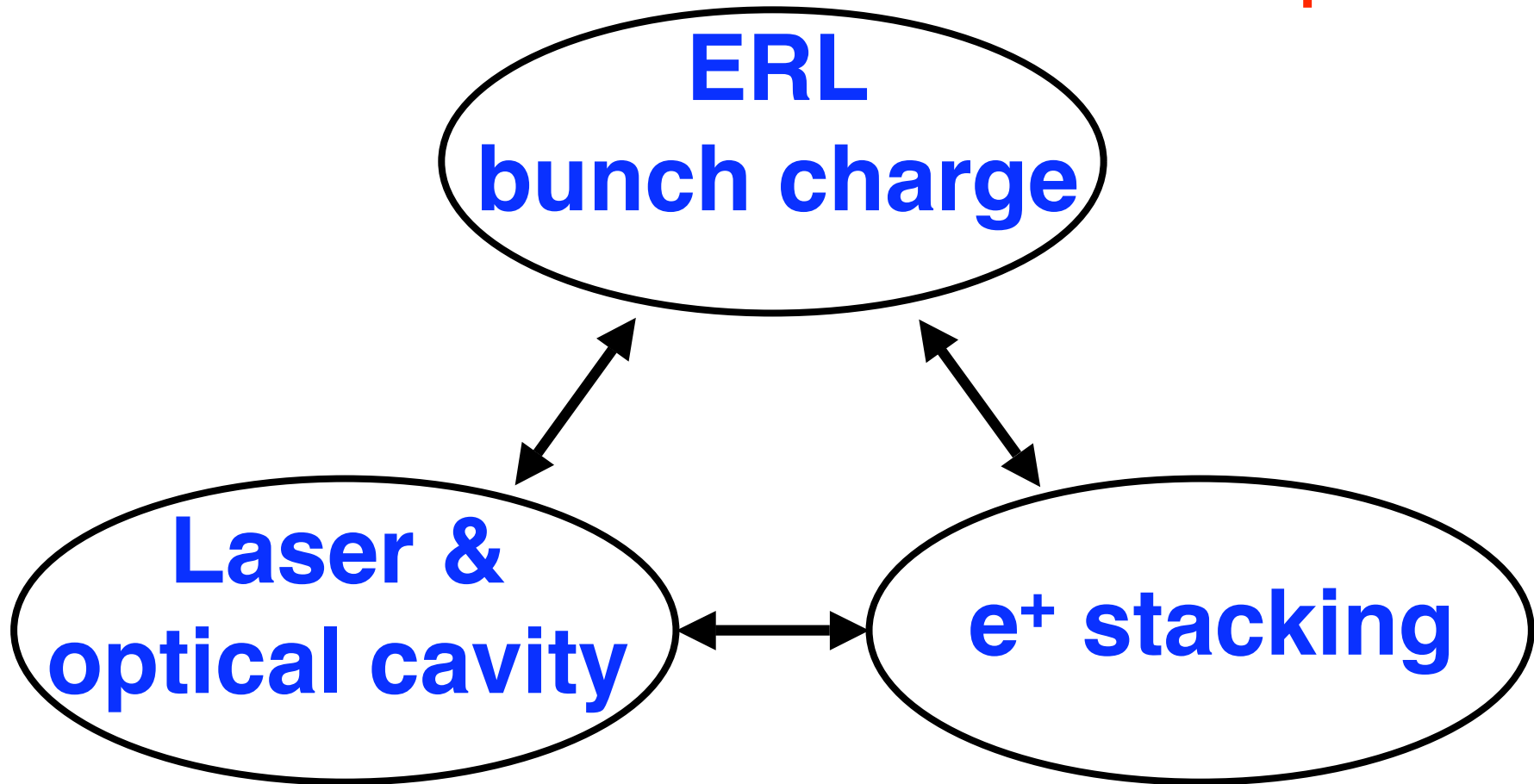


- Accelerating bunches
- Decelerating bunches



# Selection of bunch repetition: $f_{\text{rep}}$

3 factors to determine  $f_{\text{rep}}$



# Compare two choices

(a)  $f_{\text{rep}} = 163 \text{ MHz}$

$$T_{\text{b\_ERL}} = T_{\text{b\_DR}} = 6.15 \text{ nsec}$$

(b)  $f_{\text{rep}} = 40.8 \text{ MHz}$

$$T_{\text{b\_ERL}} = 4T_{\text{b\_DR}} = 24.6 \text{ nsec}$$

# Common parameters

**ERL:**  $f_{\text{RF}} = 1.3 \text{ GHz}$  ( $T_{\text{bucket-to-bucket}} = 0.77 \text{ ns}$ )

$E_{\text{e-beam}} = 1.3 \text{ GeV}$

$\sigma_z = 0.7 \text{ ps at CP}$

$\sigma_z = 2 - 3 \text{ ps in Liniac}$

**DR:**  $T_{\text{b\_DR}} = 6.15 \text{ ns}$

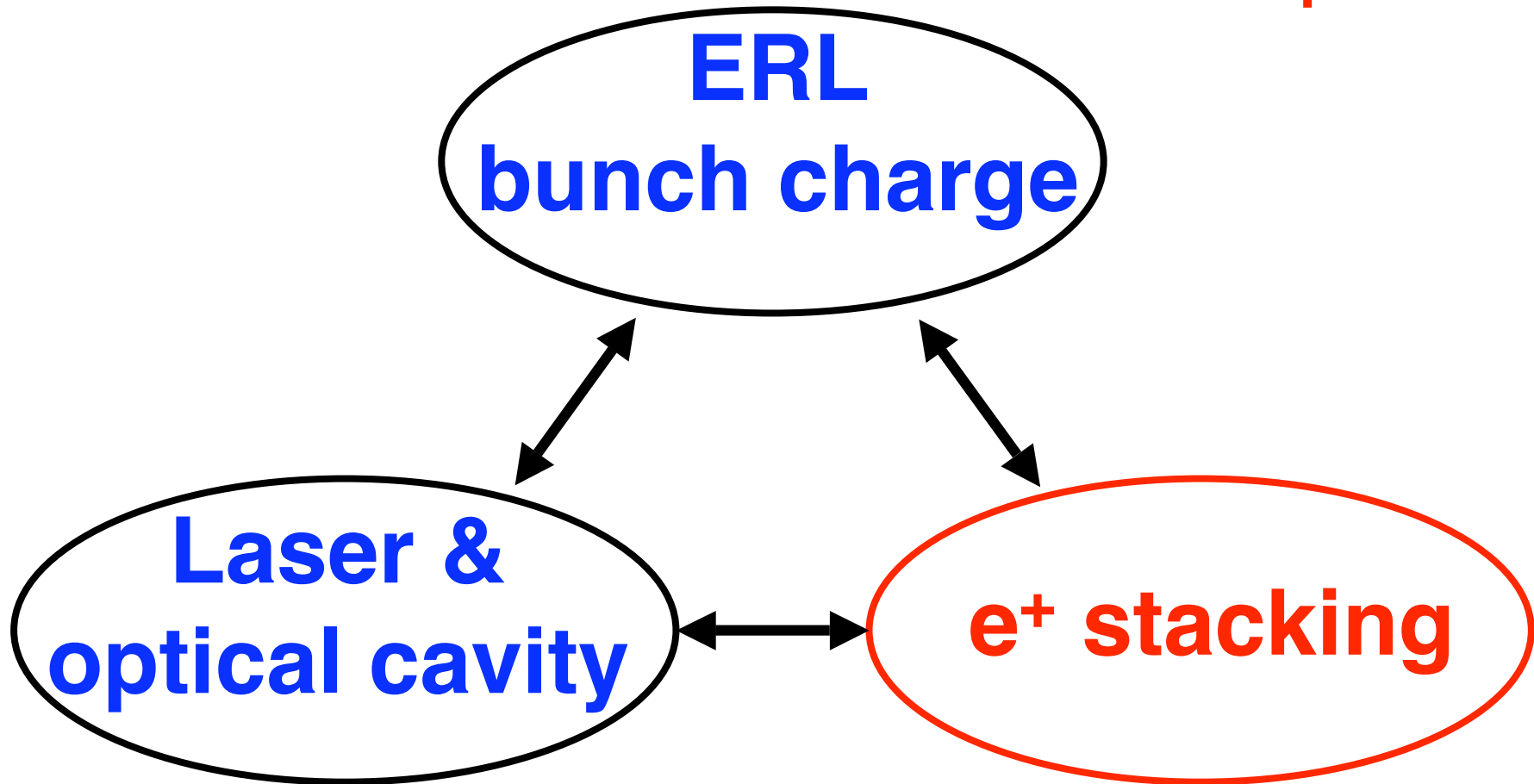
**Laser:**  $\lambda_{\text{Laser}} = 1064 \text{ nm}$

$\sigma_z = 0.8 \text{ ps at CP (after compression)}$

$\sigma_z = \sim 500 \text{ psec in Amp.}$

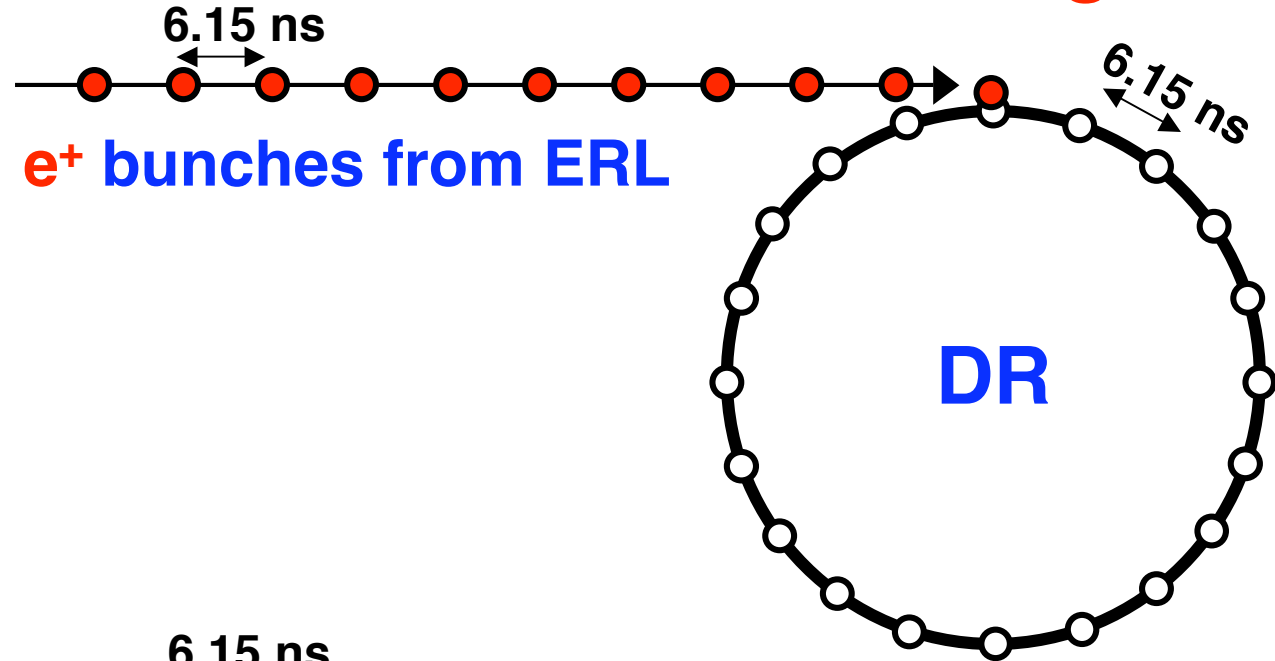
# Selection of bunch repetition: $f_{\text{rep}}$

3 factors to determine  $f_{\text{rep}}$

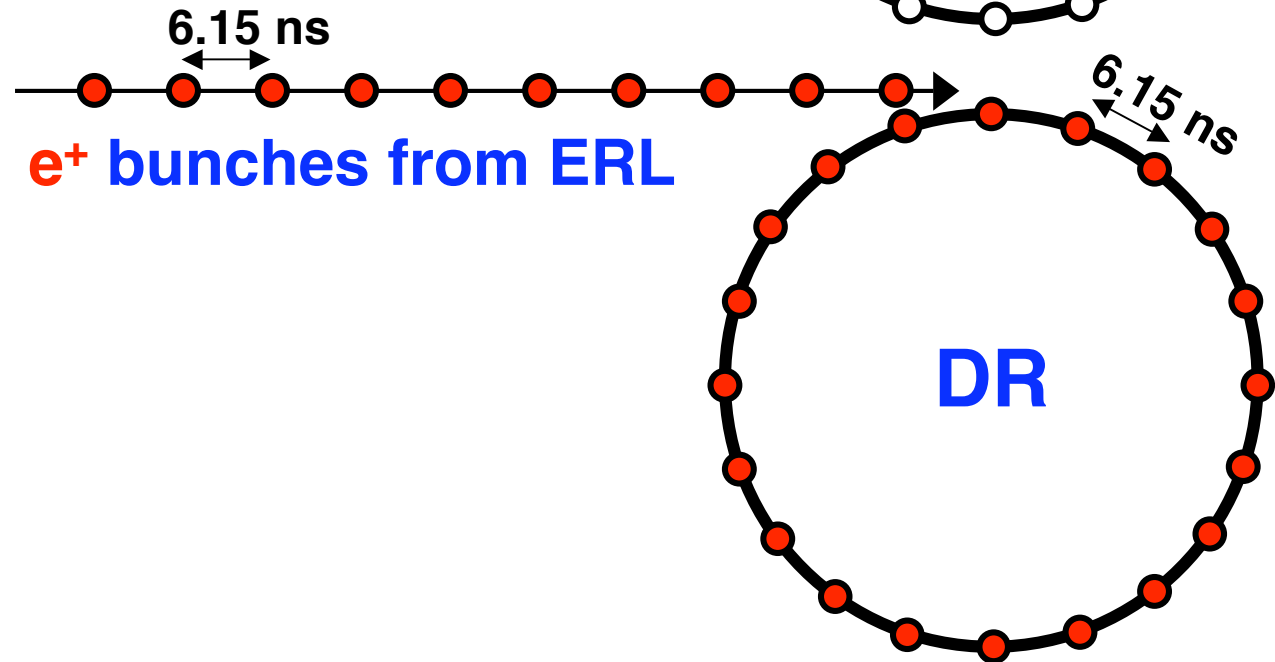


(a)  $f_{\text{rep}} = 163 \text{ MHz}$  : 1st turn of DR stacking

(1) 1st turn begin

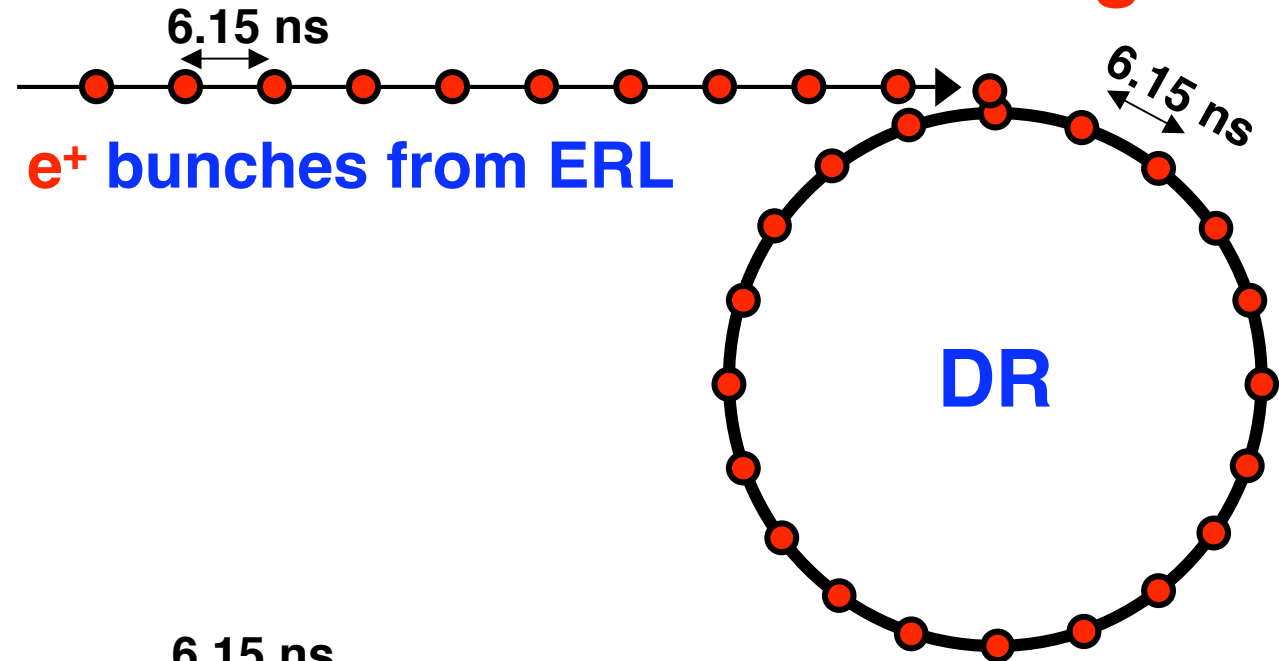


(2) 1st turn end

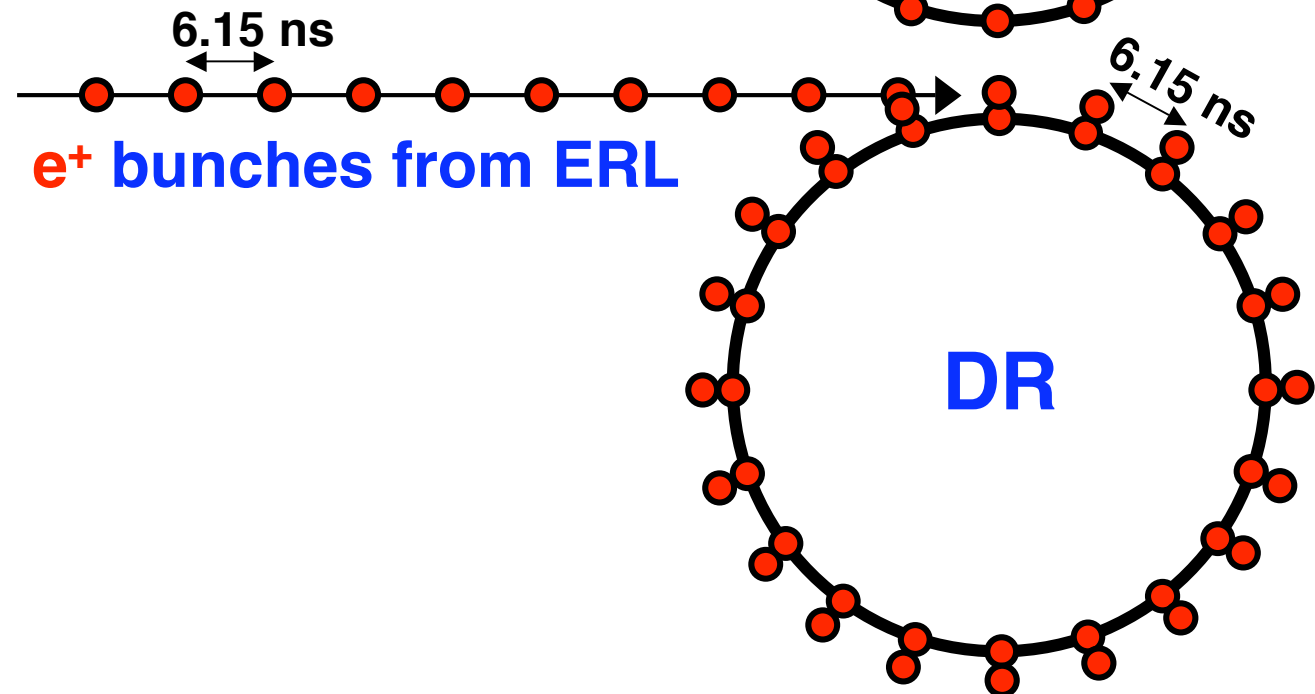


(a)  $f_{\text{rep}} = 163 \text{ MHz}$  : 2nd turn of DR stacking

(3) 2nd turn  
begin

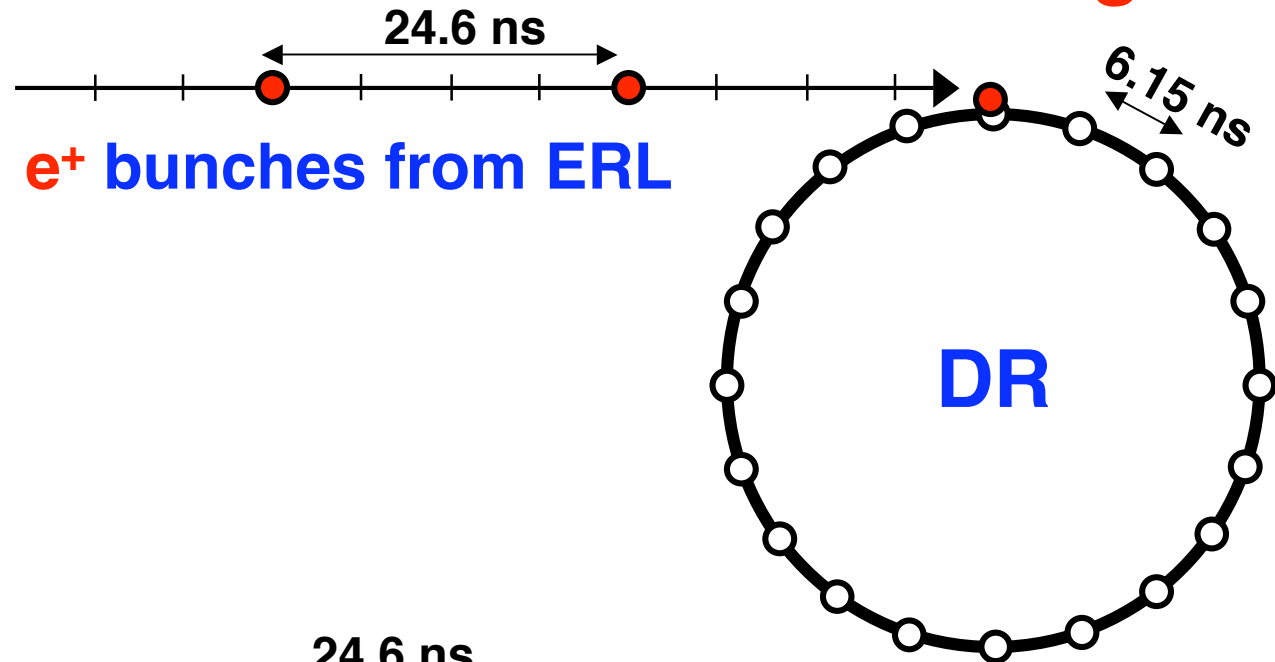


(4) 2nd turn  
end

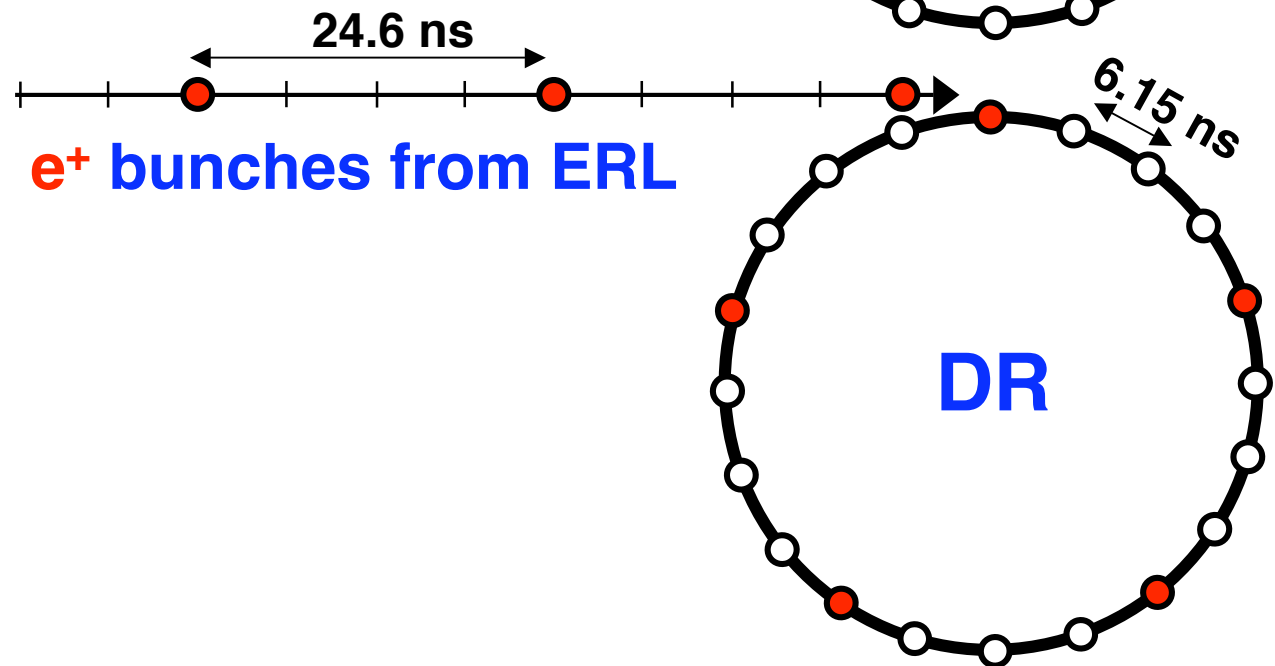


**(b)  $f_{\text{rep}} = 40.8 \text{ MHz}$  : 1st turn of DR stacking**

**(1) 1st turn begin**

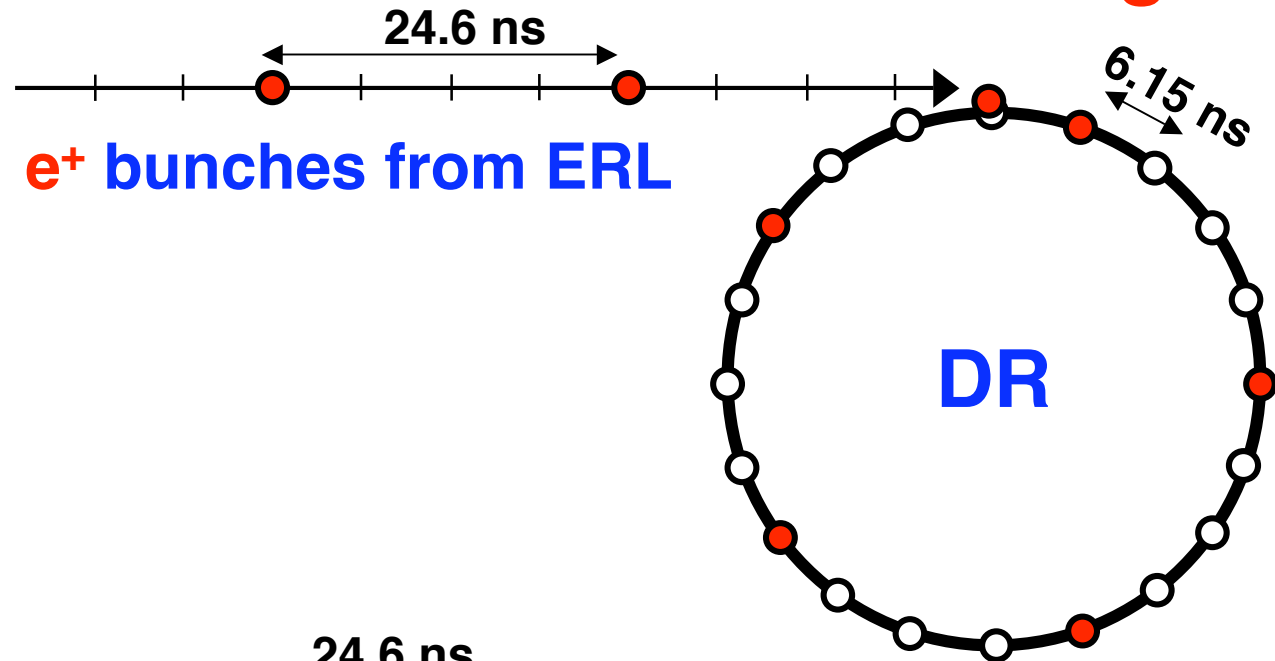


**(2) 1st turn end**

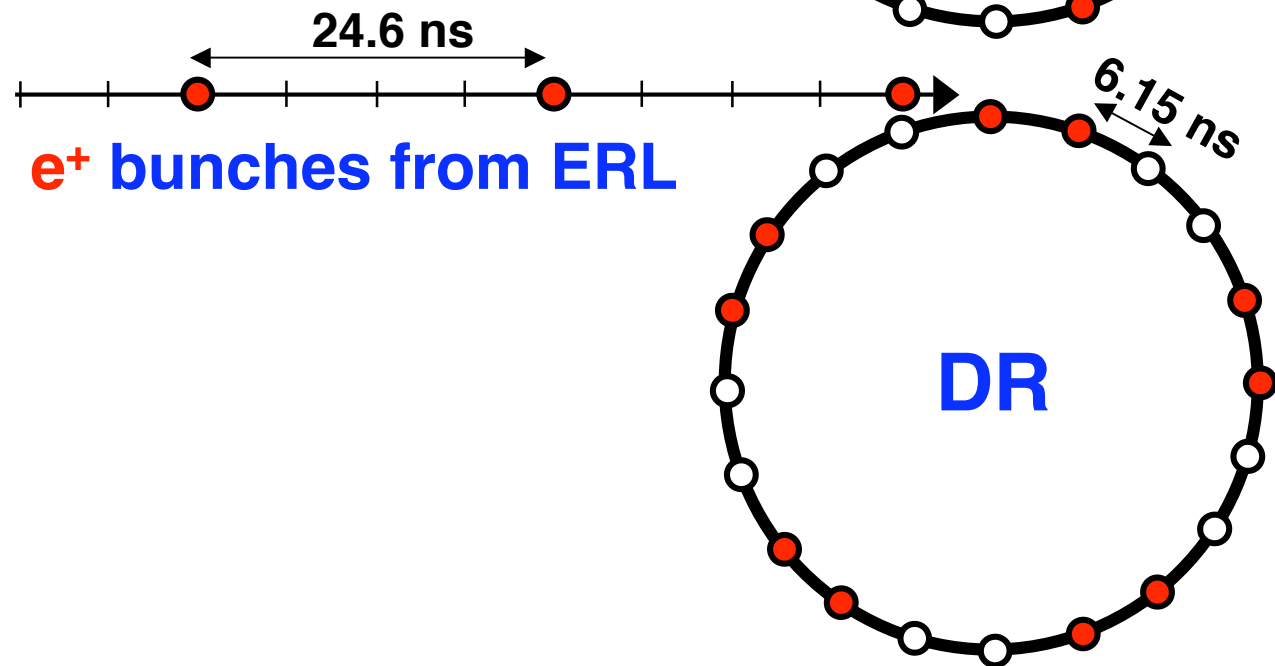


**(b)  $f_{\text{rep}} = 40.8 \text{ MHz}$  : 2nd turn of DR stacking**

**(1) 2nd turn  
begin**



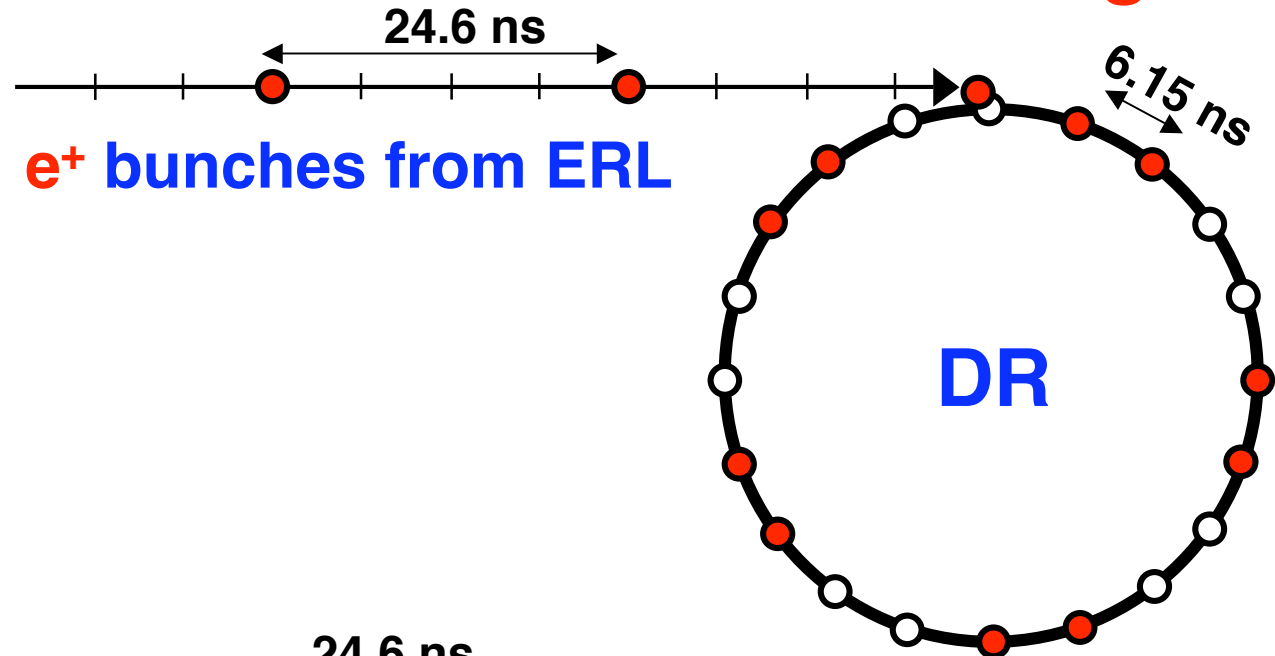
**(2) 2nd turn  
end**



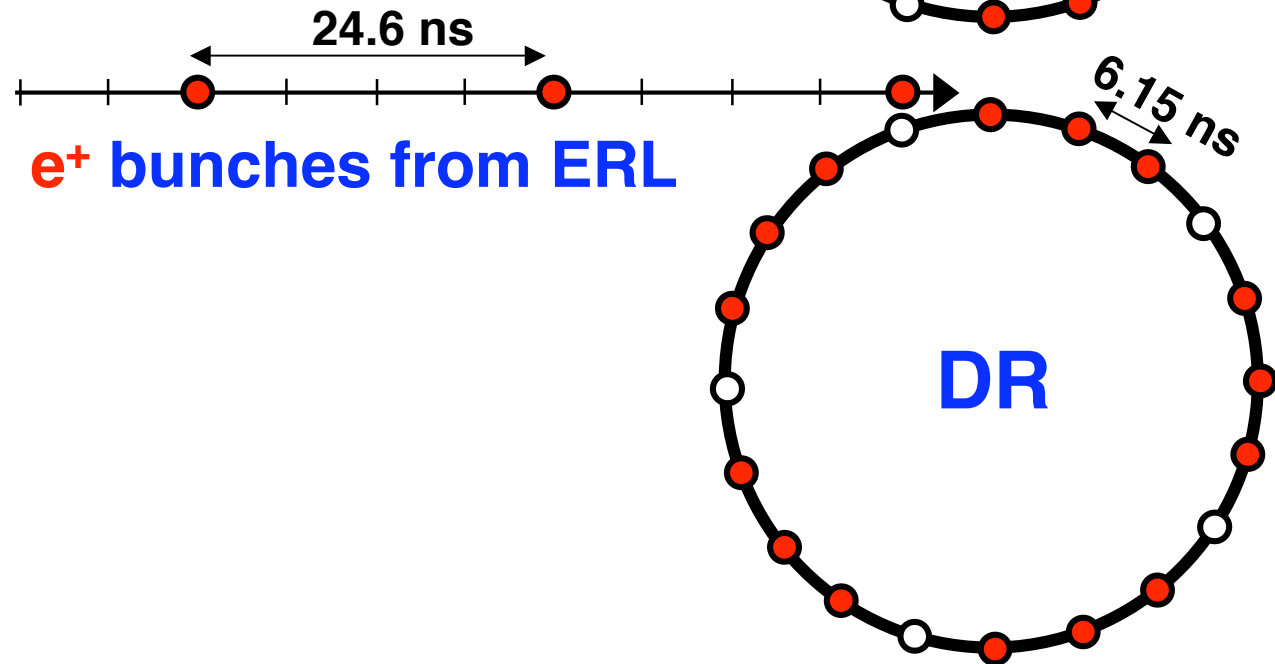


**(b)  $f_{\text{rep}} = 40.8 \text{ MHz}$  : 3rd turn of DR stacking**

**(1) 3rd turn begin**

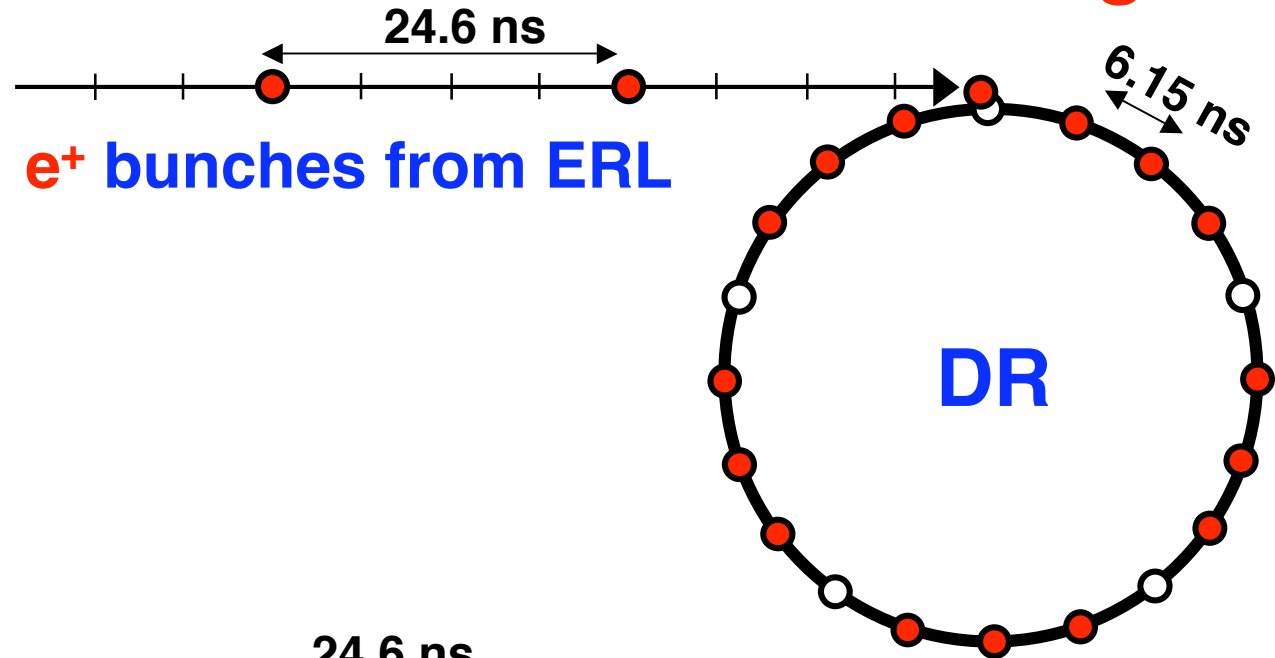


**(2) 3rd turn end**

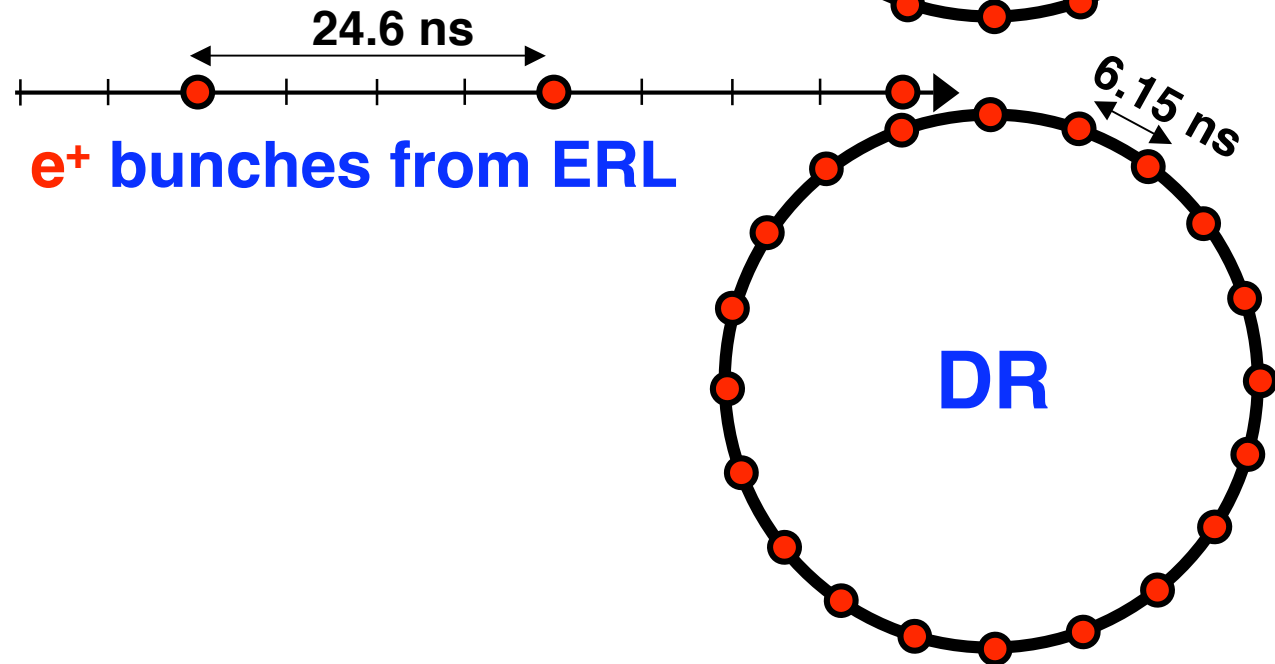


**(b)  $f_{\text{rep}} = 40.8 \text{ MHz}$  : 4th turn of DR stacking**

**(1) 4th turn  
begin**

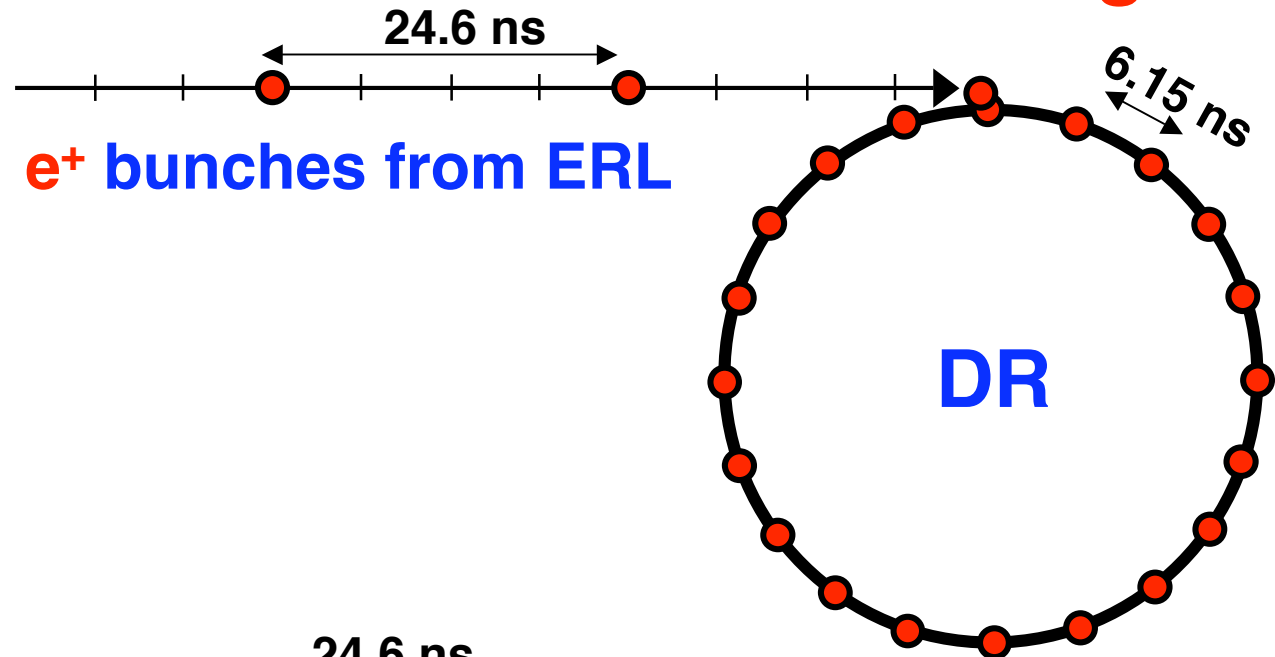


**(2) 4th turn  
end**

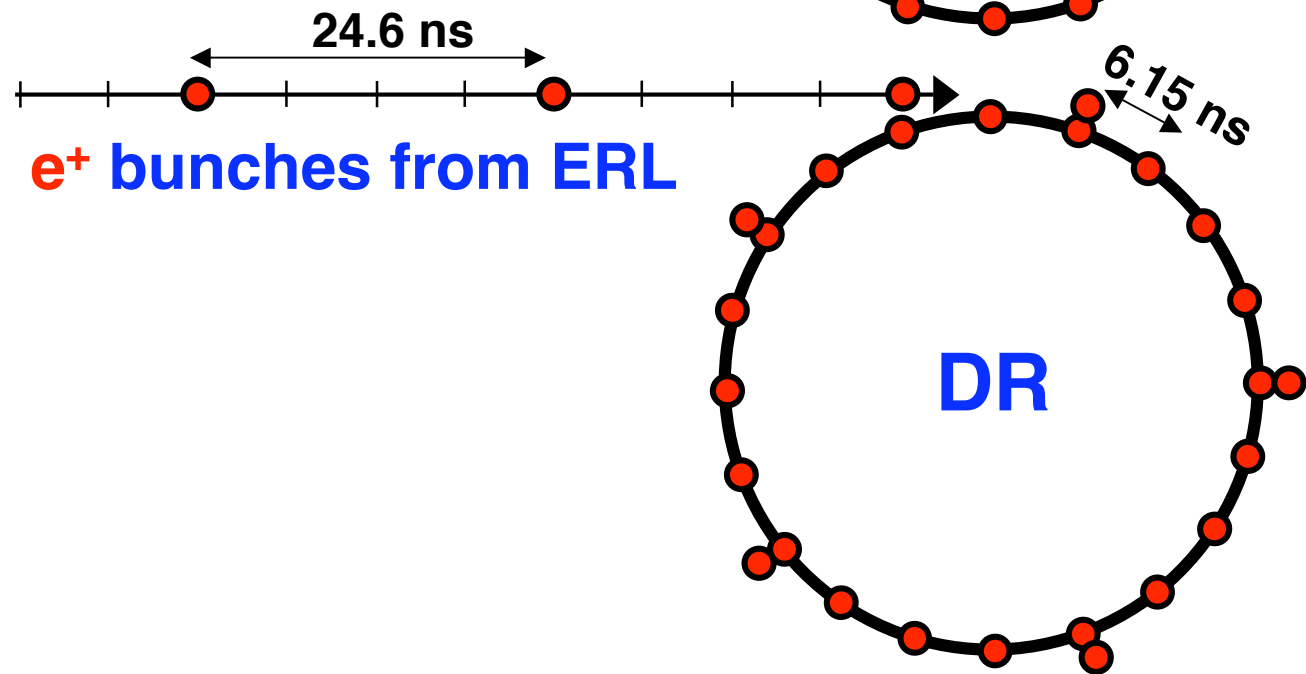


**(b)  $f_{\text{rep}} = 40.8 \text{ MHz}$  : 5th turn of DR stacking**

**(1) 5th turn begin**



**(2) 5th turn end**



**(b)  $f_{\text{rep}} = 40.8 \text{ MHz}$  : 6th-7th turn of DR stacking**

**stacking goes on.**

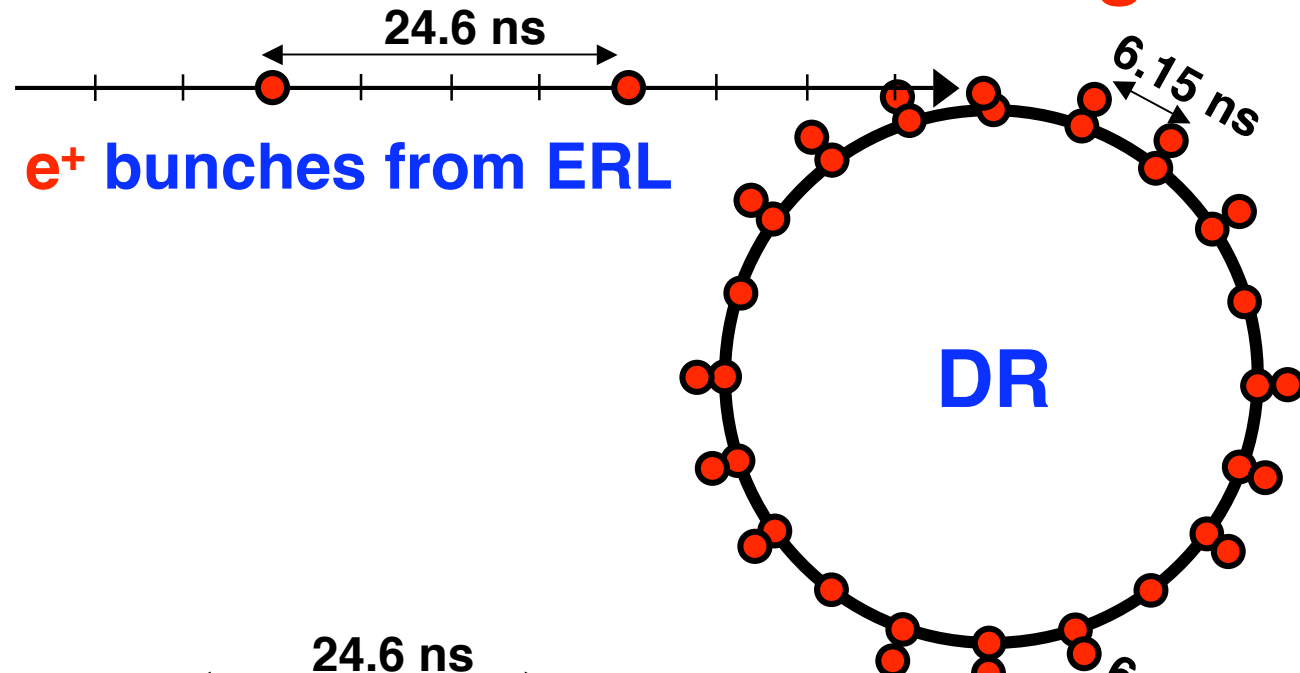
**6 th turn of DR stacking**

**7 th turn of DR stacking**

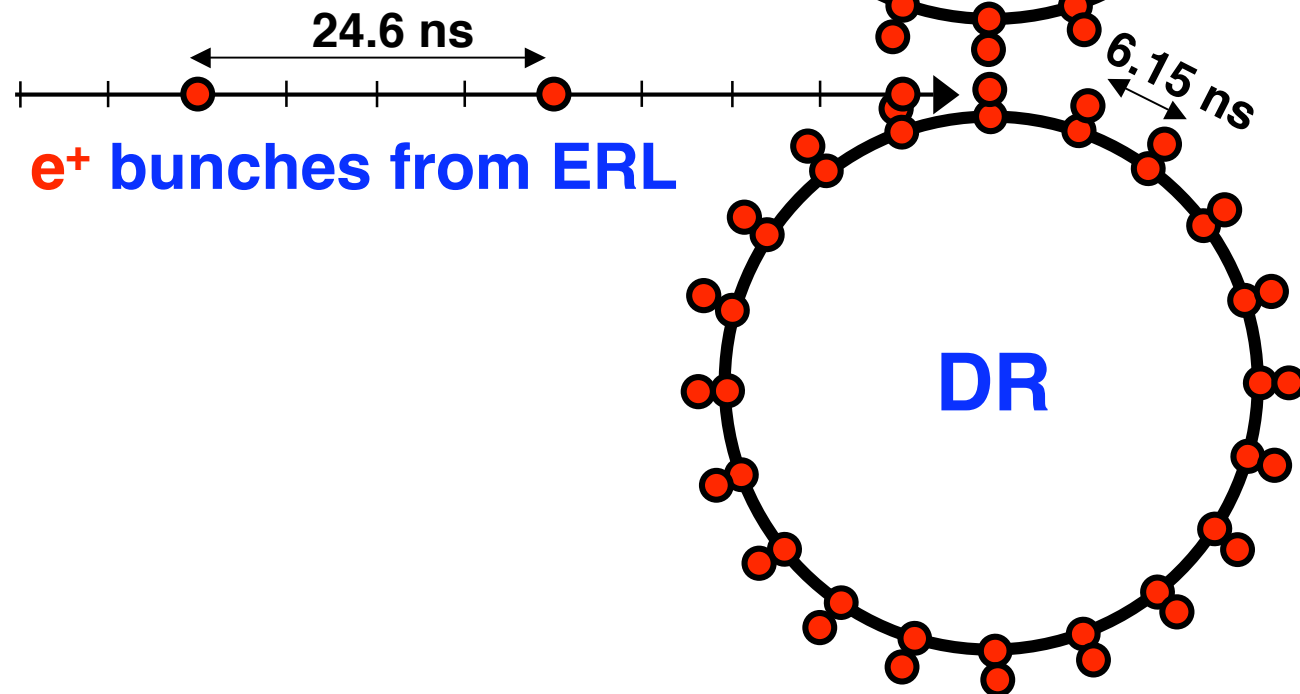
**then,**

**(b)  $f_{\text{rep}} = 40.8 \text{ MHz}$  : 8th turn of DR stacking**

**(1) 8th turn begin**



**(2) 8th turn end**



# From View point of $e^+$ stacking

(a)  $f_{\text{rep}} = 163 \text{ MHz}$

$$T_{\text{b\_ERL}} = T_{\text{b\_DR}} = 6.15 \text{ nsec}$$

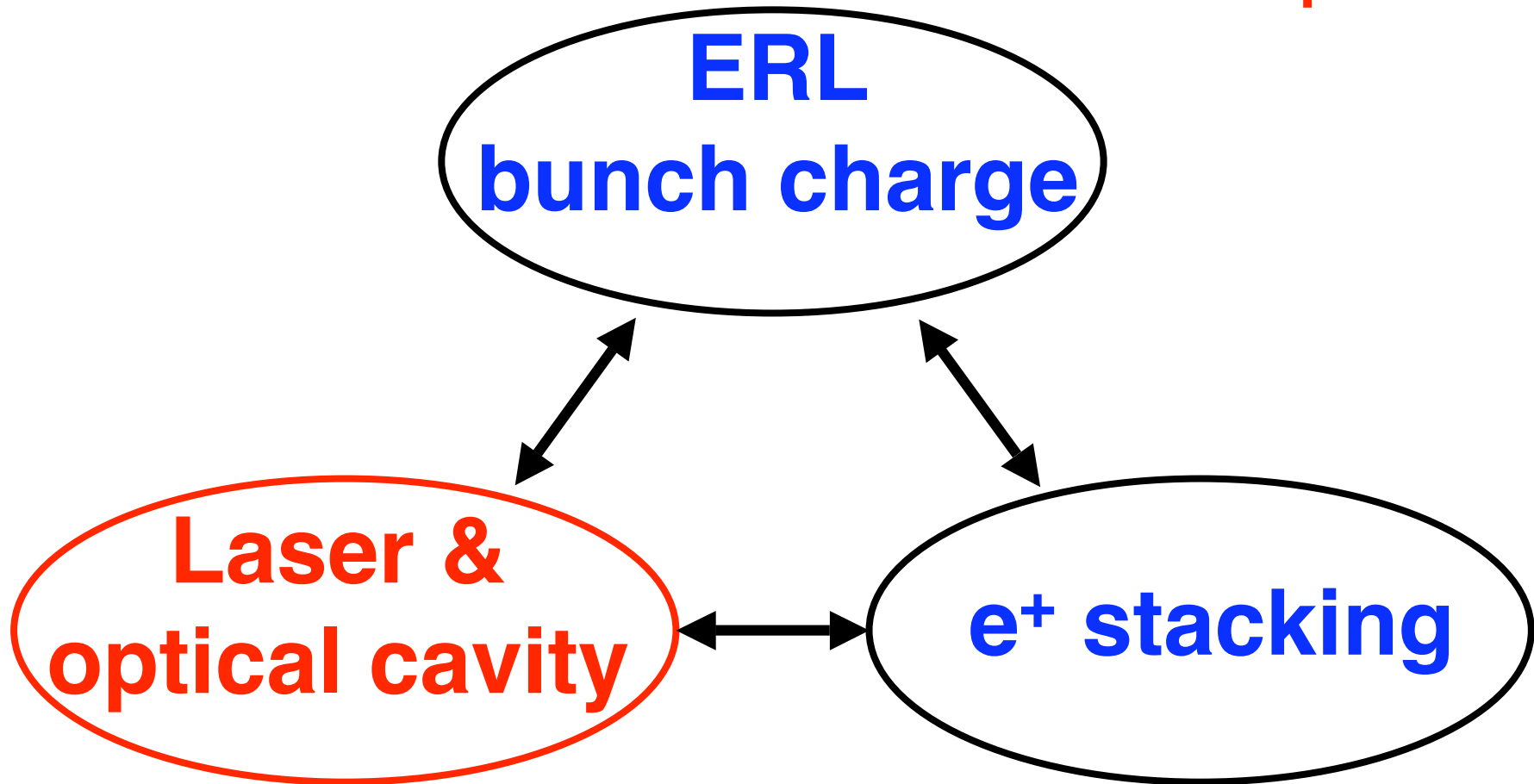
(b)  $f_{\text{rep}} = 40.8 \text{ MHz}$

$$T_{\text{b\_ERL}} = 4T_{\text{b\_DR}} = 24.6 \text{ nsec}$$

**Easier: there are 4 turns of damping (bunch position moving in phase space) before the next stacking.**

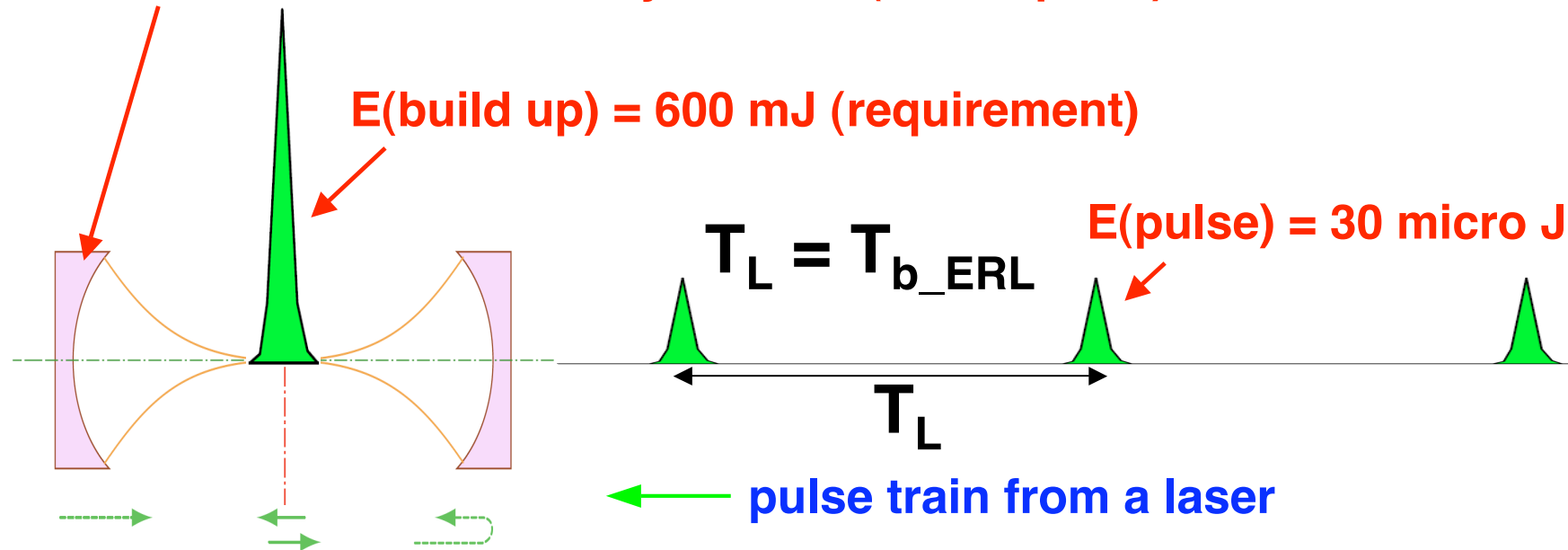
# Selection of bunch repetition: $f_{\text{rep}}$

3 factors to determine  $f_{\text{rep}}$



# Requirement to a laser

Enhancement of the cavity = 20000 (assumption)



(a)  $f_{\text{rep}} = 163 \text{ MHz}$  ( $T_{\text{b\_ERL}} = T_{\text{L}} = 6.15 \text{ ns}$ )

Laser beam power (average) = 4.8 kW

(b)  $f_{\text{rep}} = 40.8 \text{ MHz}$  ( $T_{\text{b\_ERL}} = T_{\text{L}} = 24.6 \text{ ns}$ )

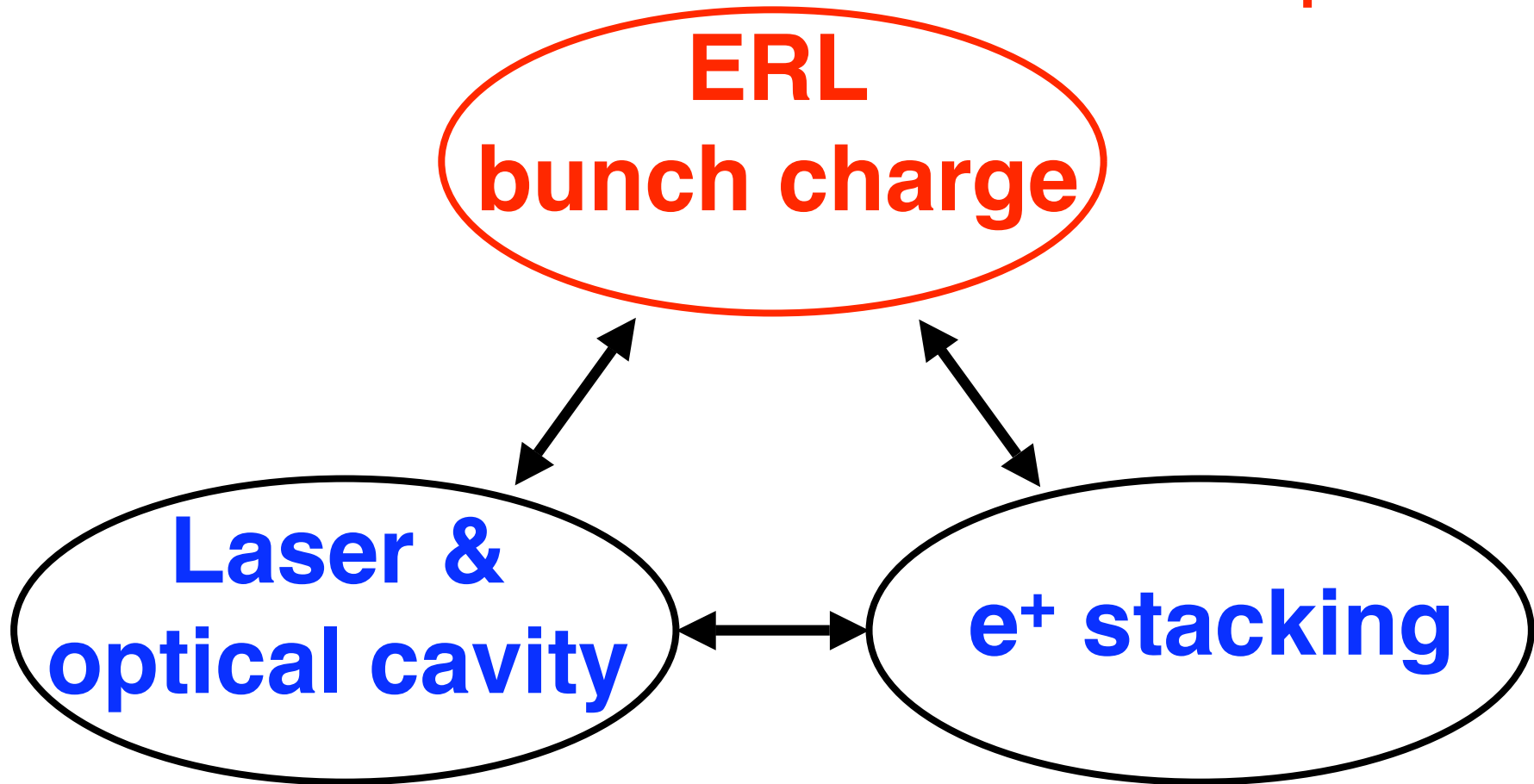
Laser beam power (average) = 1.2 kW

Easier, But, Difference exists only in average power.



# Selection of bunch repetition: $f_{\text{rep}}$

3 factors to determine  $f_{\text{rep}}$

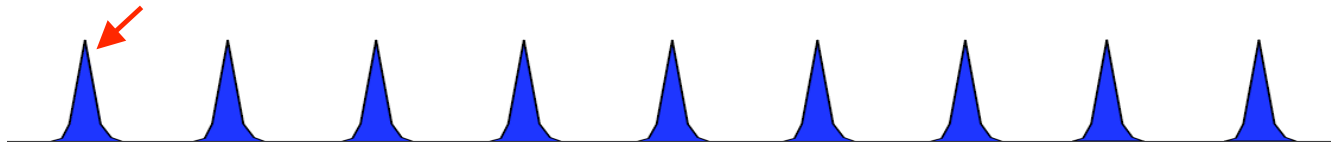


# Requirement to an ERL

**I (average) = 26 mA (assumption)**

**(a)  $f_{\text{rep}} = 163 \text{ MHz}$  ( $T_{\text{b\_ERL}} = 6.15 \text{ ns}$ )**

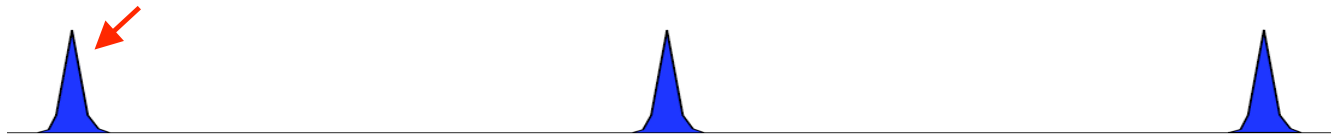
**$N_e = 1 \times 10^9$  (160pC) /bunch**



**Easier, No significant difficulty.**

**(b)  $f_{\text{rep}} = 40.8 \text{ MHz}$  ( $T_{\text{b\_ERL}} = 24.6 \text{ ns}$ )**

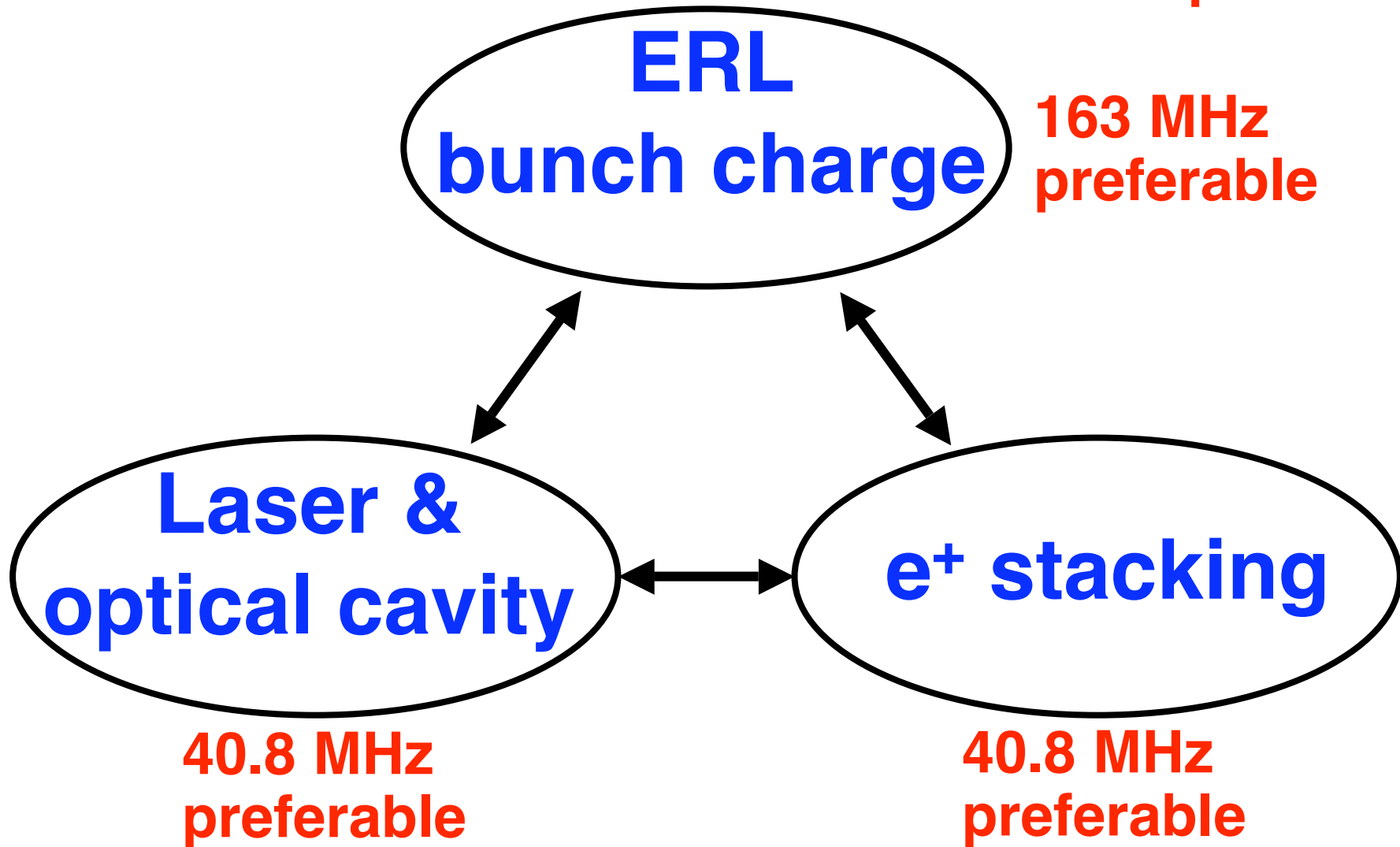
**$N_e = 4 \times 10^9$  (640pC) /bunch**



**More difficult, wake-field, charge limit at GUN, CSR,,,  
But it seems manageable .**

# Selection of bunch repetition: $f_{\text{rep}}$

3 factors to determine  $f_{\text{rep}}$



# $N_\gamma$ and $Ne^+$ in single turn of ERL

## Laser beam at CP

$$E_{\text{pulse}} = 600 \text{ mJ / cavity}$$

$$\sigma_x = \sigma_y = 5 \text{ micron}$$

$$\sigma_z = 0.7 \text{ psec}$$

## Electron beam at CP

$$\sigma_x = \sigma_y = 5 \text{ micron}$$

$$\sigma_z = 0.8 \text{ psec}$$

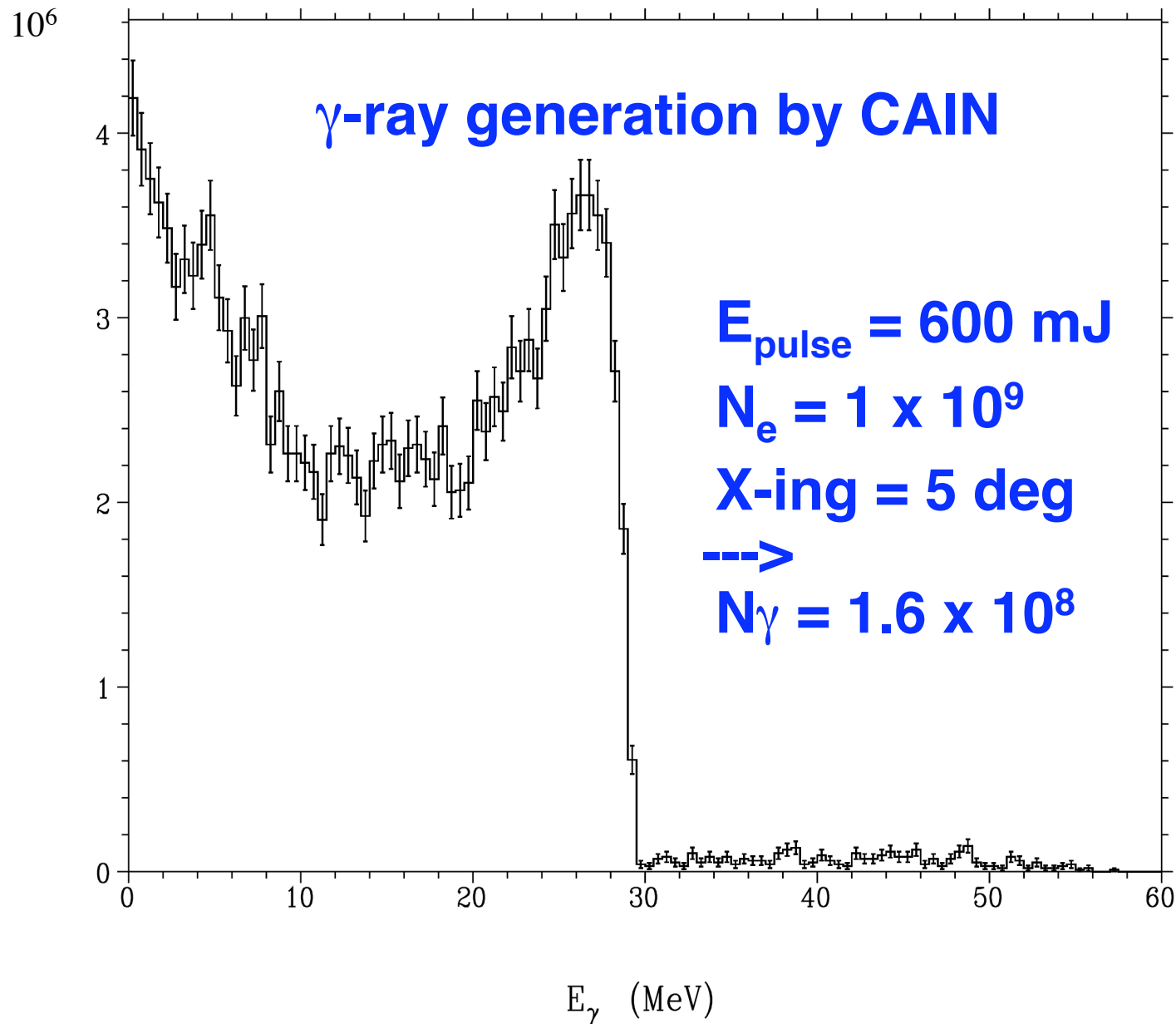
$$(a) N_e = 1 \times 10^9 \text{ (160pC) (163 MHz)} \rightarrow N_\gamma = 1.6 \times 10^8 \text{ /cavity}$$

$$(b) N_e = 4 \times 10^9 \text{ (640pC) (40.8 MHz)} \rightarrow N_\gamma = 6.4 \times 10^8 \text{ /cavity}$$

## $N_\gamma$ total (10 optical cavities, 600 mJ x 10 = 6J)

$$(a) N_\gamma = 1.6 \times 10^9 \text{ in total} \rightarrow Ne^+(\text{captured}) = 5 \times 10^6$$

$$(b) N_\gamma = 6.4 \times 10^9 \text{ in total} \rightarrow Ne^+(\text{captured}) = 20 \times 10^6$$



# Number of stacking in 100 ms

(a) 163MHz:  $N_{e^+}(\text{captured}) = 5 \times 10^6$  /ERL turn

$N_{e^+}(\text{ILC requirement}) = 2 \times 10^{10}$

-->  $N_{\text{stacking}} = 4000$  required

One turn of DR = 25 micro sec

stacking in every DR turn --> 4000 DR turns

--> 100 msec

(b) 40.8 MHz:  $N_{e^+}(\text{captured}) = 20 \times 10^6$  / ERL turn

$N_{e^+}(\text{ILC requirement}) = 2 \times 10^{10}$

-->  $N_{\text{stacking}} = 1000$  required

One turn of DR = 25 micro sec

stacking in every 4 DR turns --> 4000 DR turns

--> 100 msec

**Achieve  $N_{e^+} = 2 \times 10^{10}$  in both (a) and (b)**

# Summary

1. ERL -> easy beam compression at CPs
2. ERL -> quasi CW operation:  
top-up injection, possibility Pol.~80%
3. Two models:  
 $f_{\text{rep}} =$  (a) 163MHz and (b) 40.8MHz

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5. **Need stacking simulation**

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top-up injection, possibility Pol.~80%
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 $f_{\text{rep}} =$  (a) 163MHz and (b) 40.8MHz
4. Both of two are working assumptions.
5. Need stacking simulation, **Need ERL study**

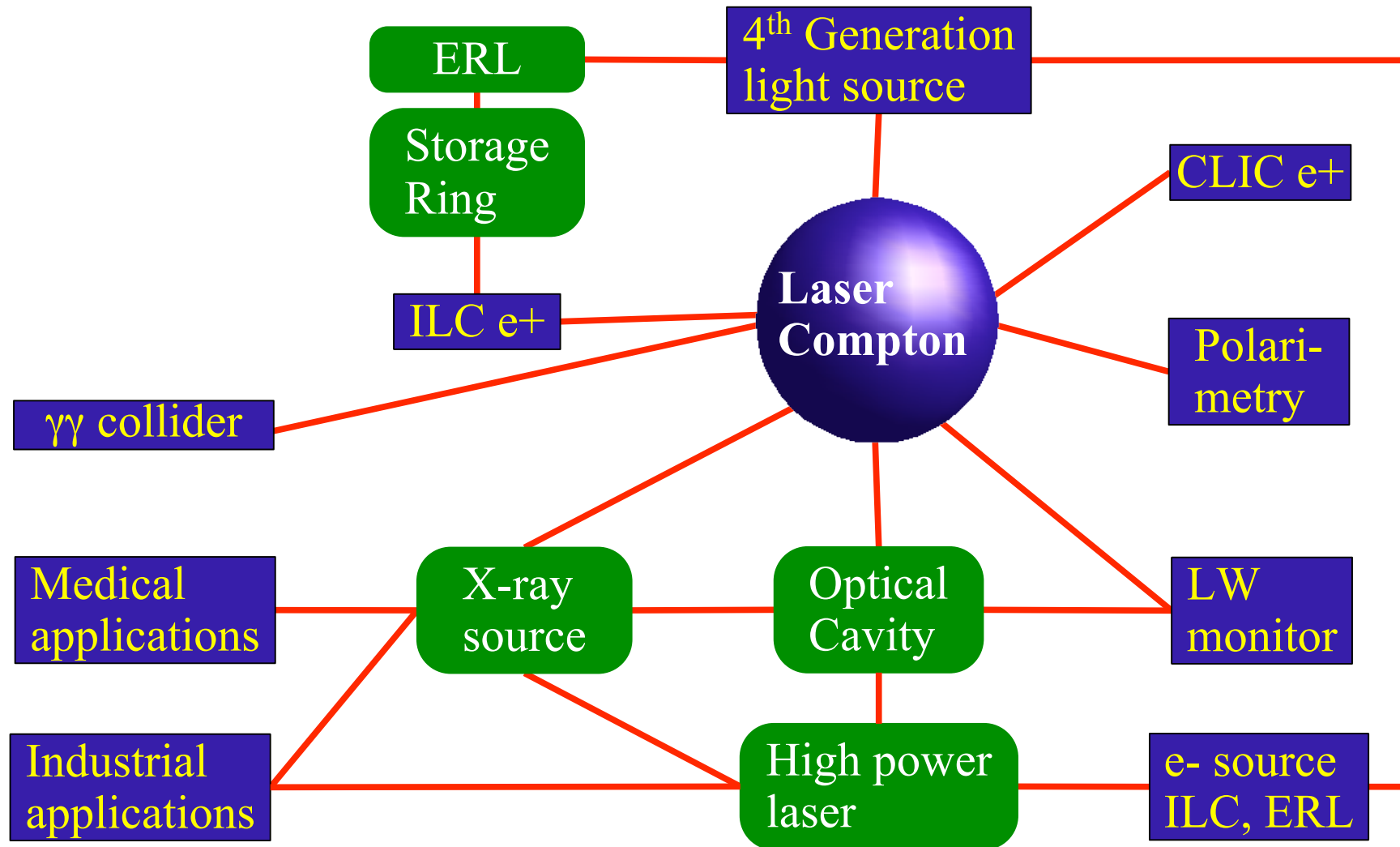
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2. ERL -> quasi CW operation:  
top-up injection, possibility Pol.~80%
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# World-Wide-Web of Laser Compton



Kuriki at Beijing e+ meeting 2007

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**The END**

**Thank you for your attention**